

TM-500

SERIES 176 — Toolmaker's Microscopes

The Mitutoyo TM Series is a toolmaker's microscope well suited for measuring dimensions and angles of workpiece features. It can also be used to check the shape of screws and gears by attaching an optional reticle. The compact body makes it ideal for use on shop-floors with limited

space for measuring instruments.

FEATURES

- Angle measurement is performed easily by turning the angle scale to align the cross-hair reticle with the workpiece image.
- Illumination intensity can be adjusted.



TM-505

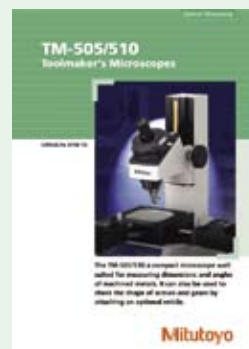


TM-510

Technical Data

Observation image:	Erect image
Optical tube:	Monocular (diopter adjustable) Depression angle: 30° Reticle: 90° broken cross-hair (176-126)
Angle reading:	Range: 360° Minimum reading: 6' (by vernier)
Eyeiece:	15X (176-116), View field dia.: 13mm Optional: 10X, 20X
Objective:	2X (176-138), Working distance: 67mm Optional: 5X, 10X
Total magnification:	30X
Transmitted illumination	
• Light source:	Tungsten bulb (24V, 2W)
• Functions:	With green filter, Light intensity adjustable
Surface illumination:	
• Light source:	Tungsten bulb (24V, 2W)
• Functions:	Light intensity adjustable
Power supply:	100/110/120/220/240V AC, 50/60Hz
Mass:	13.5g (14.5kg: TM-510)

Angle reading



Refer to the TM-505/510 leaflet (E4158) for more details.

Optional Accessories

- 176-115:** 10X eyepiece (view field dia.: 13mm)
176-116: 15X projection lens set*
176-117: 20X eyepiece (view field dia.: 10mm)
176-139: Objective, 5X (W.D.: 33mm, N.A.: 0.10)
176-137: Objective, 10X (W.D.: 14mm, N.A.: 0.14)
164-161: Digimatic micrometer head
 (range: 50mm, reading: 0.001mm)
164-162: Digimatic micrometer head (range: 2"/50mm,
 reading: .00005"/0.001mm)
152-390: Micrometer head for X-axis
 (range: 50mm, reading: 0.005mm)
152-389: Micrometer head for Y-axis
 (range: 50mm, reading: 0.005mm)
152-391: Micrometer head for X-axis
 (range: 2", reading: .0001")
152-392: Micrometer head for Y-axis
 (range: 2", reading: .0001")
611635-041: Rectangular gauge block (25mm)
611675-041: Rectangular gauge block (50mm)
611201-241: Rectangular gauge block (1")
611202-241: Rectangular gauge block (2")
383038: Halogen bulb (24V, 2W)
176-204: Dial indicator attachment for Z-axis
 measurement
965013: SPC cable (2m) for Digimatic micrometer head

Fixture and Stage accessories

- 990561:** Workpiece clip (2pcs/set)
176-106: Rotary table for TM-505 (effective dia.: 66mm)
172-196: Rotary table for TM-510 (effective dia.:
 100mm)
176-105: Swivel center support for TM-505
 (max. workpiece dia.: 70mm)
172-197: Swivel center support for TM-510
 (max. workpiece dia.: 80mm)
172-378: V-block with clamp
 (max. workpiece dia.: 25mm)
176-107: Holder with clamp

Illumination units

- 176-366:** Fiber-optic ring light
176-203: Twin-bulb reflected illumination unit
176-344: Bifurcated fiber illuminator

Reticles

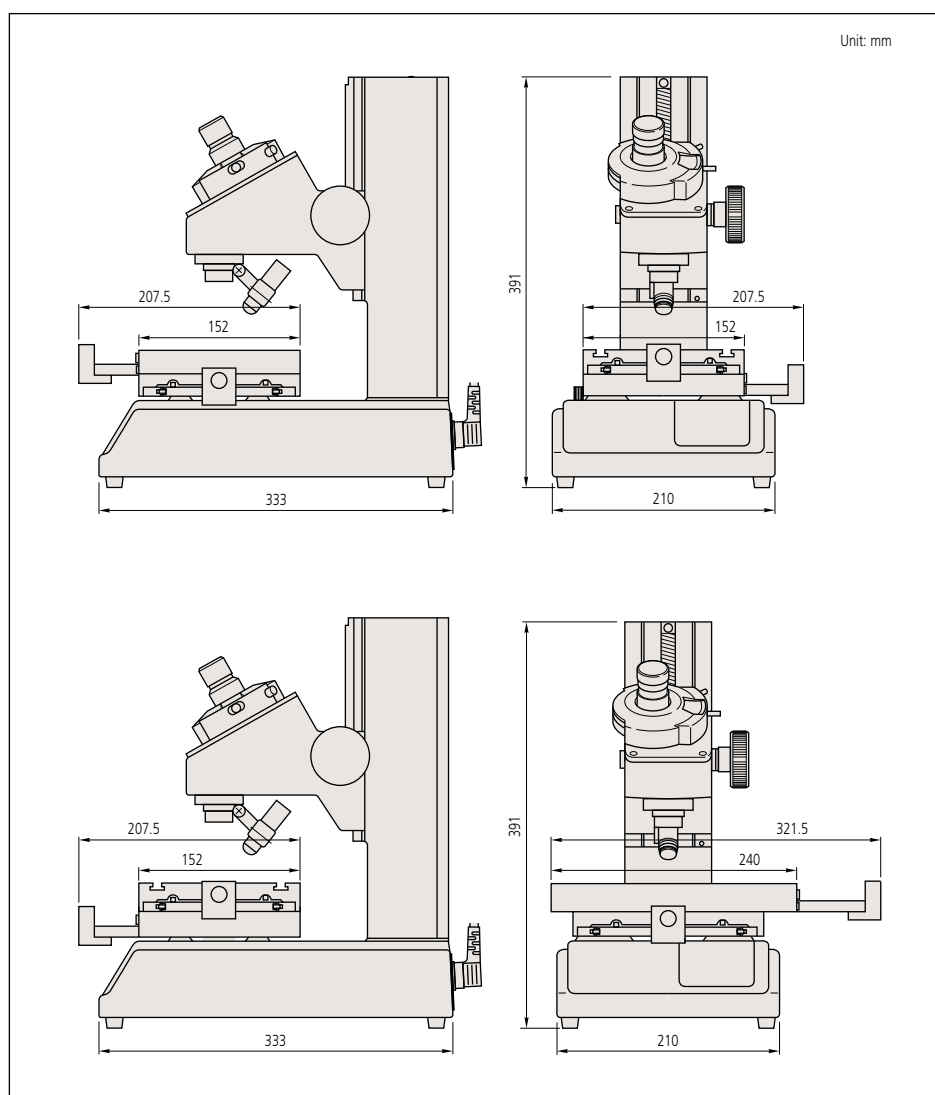
- 176-111:** Concentric circles
 (up to $\phi 4$ mm, 0.05mm increment)
176-135: Concentric circle (up to $\phi .2$ ", .01" increment)
176-113: 55° angle
176-114: 60° angle
176-109: Metric screw threads (pitch = 0.25 - 1mm)
176-110: Metric screw threads (pitch = 1.25 - 2mm)
176-140: ISO metric screw threads
 (pitch = 0.075 - 0.7mm)
176-141: ISO metric screw threads (pitch = 0.75 - 2mm)
176-142: ISO unified screw threads (80 - 28TPI)
176-143: ISO unified screw threads (24 - 14TPI)
176-144: ISO unified screw threads (13 - 10TPI)
176-123: Unified screw threads (80 - 28TPI)
176-124: Unified screw threads (24 - 14TPI)
176-125: Unified screw threads (13 - 10TPI)
176-120: Whitworth screw threads (60 - 26TPI)
176-121: Whitworth screw threads (24 - 18TPI)
176-122: Whitworth screw threads (16 - 11TPI)
176-127: NF screw threads (80 - 28TPI)
176-128: NF screw threads (24 - 14TPI)
176-129: NF screw threads (13 - 10TPI)
176-130: 14.5° involute gear teeth (normal rack type)
176-112: 20° involute gear teeth (normal rack type)

SPECIFICATIONS

Model No.	TM-505	TM-510
Order No.	176-811*	176-812*
XY stage travel range	50 x 50mm	100 x 50mm
Measurement method	Micrometer head (optional)	Micrometer head (optional)
Floating function	—	—
XY stage table top size	152 x 152mm	240 x 152mm
Effective area of table	96 x 96mm	154 x 96mm
Max. workpiece height	115mm	107mm
Max. stage loading	5kg	5kg
Remarks	—	—

* To denote your AC power cable add the following suffixes to the order No: **A** for UL/CSA, **CE** for CEE, **CEE** for BS, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK. **No suffix** is required for JIS/100V
 Note) **D** and **E** are not compatible with CE

DIMENSIONS



MF

SERIES 176 — Measuring Microscopes

The MF measuring microscopes' expandability, such as when used in combination with Mitutoyo's vision unit to boost its performance or data management on a PC, promises further improved measuring efficiency.

FEATURES

- Observation with a clear and flare-less erect image and a wide field of view
- Measuring accuracy that is the highest in its class (and conforms to JIS B 7153)
- ML series, high-NA objectives that are specially designed for the MF series (long working distance type)
- Illumination unit (reflected/transmitted) selectable from a high-intensity LED or halogen bulb (required)
- Variable aperture diaphragm (reflected/transmitted) allows observation measurement while suppressing light diffraction
- Variety of standardized stages in sizes up to 400x200mm
- Quick-release mechanism useful for moving the stage quickly when measuring workpieces that are large in size or quantity
- Coarse/fine feed handles equipped as standard on both sides allow precise focus and observation measurement regardless of handedness
- High-magnification eyepiece observation up to 2000x
- Standard measuring microscope that has a wide variety of optional accessories including a Vision Unit and various digital CCD cameras



Using optional slide type nosepiece with 2-lens mount (factory set option)

MF-B2017C
XY stage travel range: 200 x 170mm
(with optional binocular tube)

Selection of XY stage by travel range

505C: 50 x 50mm



1010C: 100 x 100mm



2010B: 200 x 100mm



3017C: 300 x 170mm



4020C: 400 x 200mm



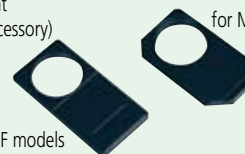
Technical Data

Observation image:	Erect image
Optical tube (optional):	Monocular or binocular tube (depression: 25°), Reticle projection method, with TV mount, Optical path ratio (eyepiece/TV mount: 50/50)
Eyepiece lens (optional):	10X, 15X, 20X
Objective:	3X (375-037), W.D.: 72.5mm Optional: 1X, 5X 10X, 20X, 50X, 100X
Transmitted illumination	
• Light source:	Halogen bulb (12V, 50W)
• Optical system:	Telecentric illumination with adjustable aperture diaphragms
• Functions:	Light intensity adjustable, Non-stepped brightness adjustment Surface illumination
• Light source:	Halogen bulb (12V, 150W)
• Optical system:	Koehler illumination with adjustable aperture diaphragms
• Functions:	Light intensity adjustable, Non-stepped brightness adjustment Display unit:
• No. of axis:	2 axes (MF-A type) or 3 axes (MF-B type)
• Resolution:	0.001mm / 0.0005mm / 0.0001mm / .0001" / .00005" / .00001"
• Functions:	Zero-setting, Direction switching, Data output (via RS-232C interface)
Power supply:	100/110/120/220/240V AC, 50/60Hz
Mass:	65.5kg (505C, 1010C) / 69.5kg (2010C) / 130kg (2017C) / 138kg (3017C) / 144kg (4020C)

Optional Reticles for 3X Eyepiece

- 12AAG838 (12AAG878):** Cross-hair (7μm width)
12AAG836 (12AAG877): Cross-hair (5μm width)
12AAG873 (12AAG876): Cross-hair (3μm width)
12AAG839 (12AAG879): Cross-hair and 45° angle
12AAG840 (12AAG880): Broken cross-hair and 60° angle
12AAG841 (12AAG881): Zeiss type chart
12AAG842*: 20mm scale (0.1mm reading)
12AAG843*: Concentric circle (ø1.2 - ø18mm)
12AAG844*: 10mm scale (0.1mm reading)
12AAG845*: 5mm scale (0.05mm reading)
12AAG846*: 10x10mm section (1mm min.)
12AAG847*: Metric screw thread (P = 0.25-1.0)
12AAG848*: Metric screw thread (P = 1.25-2.0)
12AAG849*: Involute gear tooth (14.5°), module = 0.1 - 1.0
12AAG850*: Involute gear tooth (20°), module = 0.1 - 1.0
12AAG851*: Unified screw thread (80 - 28TPI)
12AAG852*: Unified screw thread (24 - 14TPI)
12AAG853*: Unified screw thread (13 - 10TPI)
12AAG854*: Concentric circle (ø.01" - ø.2")
 () : for MF-U models, *: MF/MF-U compatible

Reticle mount (standard accessory) for MF-U models



for MF models

90° chain line
Line width: 5μm
(standard accessory)



Refer to the MF /MF-U leaflet (E4153) for more details.

Optional Accessories

- 176-392:** Monocular tube with 10X eyepiece
176-393: Binocular tube with 10X eyepiece set
378-856: 10X eyepiece set (view field dia.: 24mm)
378-857: 15X eyepiece set (view field dia.: 16mm)
378-858: 20X eyepiece set (view field dia.: 12mm)
375-043: Protractor eyepiece (10X)
176-313: Digital protractor eyepiece (10X)
375-036-2: 1X objective (W.D.: 61mm, N.A.: 0.03)
375-037-1: 3X objective (W.D.: 77mm, N.A.: 0.09)
375-034-1: 5X objective (W.D.: 61mm, N.A.: 0.13)
375-039: 10X objective (W.D.: 51mm, N.A.: 0.21)
375-051: 20X objective (W.D.: 20mm, N.A.: 0.42)
375-052: 50X objective (W.D.: 13mm, N.A.: 0.55)
375-053: 100X objective (W.D.: 6mm, N.A.: 0.7)
176-314-1: Slide type nosepiece (2-mount, parfocal)
176-314-2: Slide type nosepiece (2-mount, mag. adjusted)
12AAA643: ND2 color filter (transmitted / surface)
12AAA644: ND8 color filter (transmitted / surface)
12AAA645: GIF filter (transmitted / surface)
12AAA646: LB80 color filter (transmitted / surface)
375-054: 0.5X camera adapter (with C-mount adapter)
970441: C-mount adapter
513667: Halogen bulb (24V, 50W)
12BAB345: Halogen bulb (long life type, 24V, 50W)
176-308: Vibration damping stand
176-309: Mounting stand
375-056: Stage micrometer
12AAA165: Lens cleaning kit
12AAA846: Foot switch

Illumination units (Refer to page J-25.)

- 176-351-6:** Oblique surface illumination unit
176-367-2: LED ring illuminator
176-343: Twin fiber-optics illuminator
176-366: Ring fiber-optics illuminator
12AAG806: GIF color filter (for fiber-optics illuminator)
12AAG807: LB80 color filter (for fiber-optics illuminator)

Fixture and Stage accessories (Refer to page J-15.)

- 176-107:** Holder with clamp*
172-378: V-block with clamp*
(max. workpiece dia.: 25mm)
172-197: Swivel center support*
(max. workpiece dia.: 80mm)
176-305: Rotary stage with fine feed knob for
505C/1010C/2010C models
176-306: Rotary stage with fine feed knob for
2017C/3017C/4020C models

*Fixture mount adapter (**176-310**) is required for 2010B models.

Fixture mount adapter (**176-304**) is required for 2017B/3017B/4020B models.



QM-Data200

2-D data processing unit
(Refer to page J-14 for more details.)

12AAA807: Connecting cable set

Focus pilot FP-05
Focus assisting system
(Refer to page J-24 for more details.)



Vision Unit

PC-based vision measuring system
(Refer to page J-28 for more details.)



SPECIFICATIONS

Model No. (XY stage size)	505C	1010C	2010C	2017C	3017C	4020C
Order No.*	MF-A	176-661*	176-662*	176-663*	176-664*	176-665*
	MF-B	176-681*	176-682*	176-683*	176-684*	176-685*
XY stage travel range	50 x 50mm	100 x 100mm	200 x 100mm	200 x 170mm	300 x 170mm	400 x 200mm
Z-axis travel range	150mm	150mm	150mm	220mm	220mm	220mm
Focusing method	Manual focusing (coarse focusing: 30mm/rev., fine focusing: 0.2mm/rev.)					
Measurement method	Linear encoder (2-axis model: X / Y-axis, 3-axis model: X / Y / Z-axis)					
Resolution (switchable)	0.001mm / 0.0005mm / 0.0001mm / .0001" / .00005" / .00001"					
Measuring accuracy (at 20°C)	XY-axes: (2.2+0.02L)μm, L = Measuring length (mm) when not loaded, JIS B 7153					
Indication accuracy (at 20°C)	Z-axis: (5+0.04L)μm, L = Measuring length (mm)					
Floating function	X and Y axes with Quick-release mechanism					
XY stage top size	280 x 280mm	280 x 280mm	350 x 280mm	410 x 342mm	510 x 342mm	610 x 342mm
Effective glass size	180 x 180mm	180 x 180mm	250 x 150mm	270 x 240mm	370 x 240mm	440 x 240mm
Swiveling function	—	—	—	±5° (left)	±5° (left)	±3° (left)
Max. stage loading	10kg	10kg	10kg	20kg	20kg	15kg
Max. workpiece height	150mm	150mm	150mm	220mm	220mm	220mm

* The following suffixes to the order No. (e.g.: **176-661-10**):

-10 for English User's Manual 11 for Chinese user's manual, No suffix is Japanese user's manual

Selection of machine type

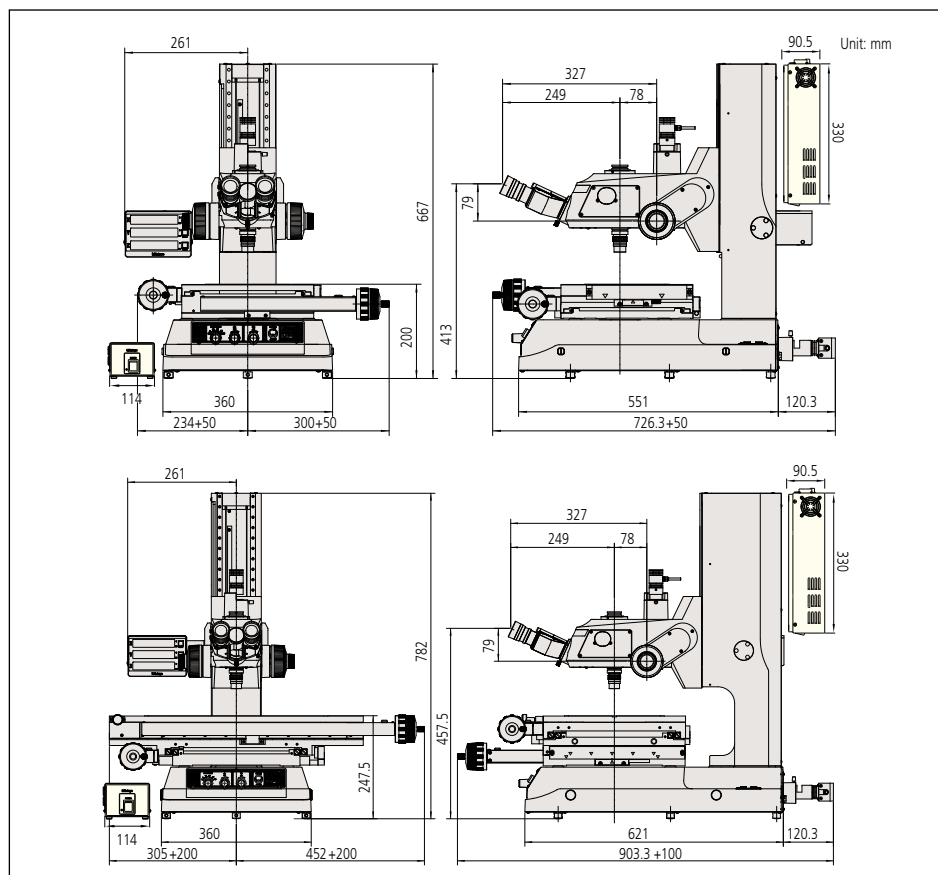
Machine type	MF-A	MF-B
Measurement system	X and Y-axis (2-axes type)	X, Y and Z-axis (3-axis type)

Illumination Unit

Applicable Illumination Unit	LED	Halogen
Order No.	176-345*	176-347*

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

DIMENSIONS



MF-U

SERIES 176 — High-power Multi-function Measuring Microscopes

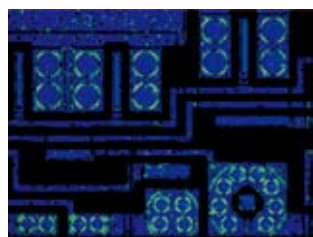
FEATURES

- Observation with a clear and flare-less erect image and a wide field of view
- Measuring accuracy that is the highest in its class (and conforms to JIS B 7153)
- Proven high-NA objectives from the FS optical system (long working distance type)
- Integration of metallurgical and measurement microscope functions provides high-resolution observation and high-accuracy measurement solution
- Illumination unit (reflected/transmitted) selectable from a high-intensity LED or halogen bulb (required)
- Variable aperture diaphragm (reflected/transmitted) allows observation measurement while suppressing light diffraction
- Variety of standardized stages in sizes up to 400 × 200 mm
- Quick-release mechanism useful for moving the stage quickly when measuring workpieces that are large in size or quantity
- High-magnification eyepiece observation up to 4000X
- Low-noise design



MF-UB3017C

XY stage travel range: 300 x 170mm
(with optional turret, objective and fiber illumination)



Polarized light observation:

Observing only the filtered light that vibrates in one direction. Used for observing materials with special optical characteristics, such as mineral and liquid crystal.



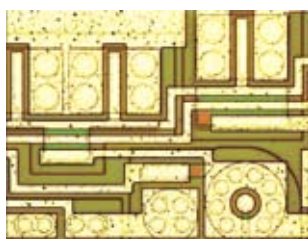
Dark field (DF) observation:

Observing only the scattered light by shutting down the direct light to the objectives. The scratches and dust that cannot be viewed in the bright view field can be observed by this method in high-contrast.



Differential interference contrast (DIC) observation:

Effective in detecting fine scratches and steps on the surface of metal, liquid crystal, and semiconductors.



Bright field (BF) observation:

Most common method of observation. Observing directly the light reflected from the surface of the workpiece.

Technical Data

Observation image:	Erect image
Optical tube:	Siedentoph type (pupil distance adjustment: 51 - 76mm), 1X tube lens, Binocular tube (depression: 30°), Reticle projection method, with TV mount, Optical path ratio (eyepiece/TV mount: 50/50)
Eyepiece lens:	10X (field No.: 24mm), Optional: 15X, 20X
Turret (optional):	Manual or power
Objective (optional):	M / BD Plan Apo objective from 1X to 100X (Refer to page J-36 for more details.)
Transmitted illumination	
• Light source:	Halogen bulb (12V, 50W)
• Optical system:	Telecentric illumination with adjustable aperture diaphragms
• Functions:	Light intensity adjustable, Non-stepped brightness adjustment
Surface illumination	
• Light source:	Optional halogen illumination unit (fiber-optic cold light illumination)
• Optical system:	Koehler illumination with adjustable aperture diaphragms
• Functions:	Light intensity adjustable, Non-stepped brightness adjustment
Display unit:	
• No. of axis:	2 axes or 3 axes
• Resolution:	0.001mm / 0.0005mm / 0.0001mm / .0001" / .00005" / .00001"
• Functions:	Zero-setting, Direction switching, Data output (via RS-232C interface)
Power supply:	100/110/120/220/240V AC, 50/60Hz
Mass:	65.5kg (505C, 1010C) / 69.5kg (2010C) / 130kg (2017C) / 138kg (3017C) / 144kg (4020C)

Selection of XY stage by travel range



505C: 50 x 50mm



1010C: 100 x 100mm



2010C: 200 x 100mm



2017C: 200 x 170mm



4020C: 400 x 200mm

Optional Accessories

- 378-857:** 15X eyepiece set (view field dia.: 16mm)
378-858: 20X eyepiece set (view field dia.: 12mm)
—: Objective (See page J-36.)
378-018: Adjustable manual BF turret
378-116: Adjustable power BF turret
176-211: Adjustable manual BF/DF turret
378-210: Adjustable power BF/DF turret
—: Reticles (See page J-18.)
178-092: Polarization unit
378-076: DIC unit for 100X, SL80X, SL50X objective
378-078: DIC unit for 50X, SL20X objective
378-079: DIC unit for 20X objective
378-080: DIC unit for 10X, 5X objective
12AAA643: ND2 color filter
12AAA644: ND8 color filter
12AAA645: GiF filter
12AAA646: LB80 color filter
375-054: 0.5X camera adapter
 (with C-mount adapter)
970441: C-mount adapter
513667: Halogen bulb (24V, 50W)
12BAB345: Halogen bulb (long life type, 24V, 50W)
517181: Halogen bulb (24V, 100W)
12BAD602: High intensity halogen bulb (24V, 100W)
176-308: Vibration damping stand
176-309: Mounting stand
375-056: Stage micrometer
12AAA165: Lens cleaning kit
12AAA846: Foot switch

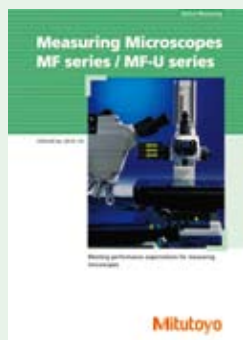
Illumination units (Refer to page J-25.)

- 176-315:** Halogen illumination unit (12V, 100W)
176-316: Halogen illumination unit (12V, 150W)
176-343: Twin fiber-optics illuminator
12AAG806: GiF color filter (for **176-315**)
12AAG807: LB80 color filter (for **176-315**)

Fixture and Stage accessories (Refer to page J-15.)

- 176-107:** Holder with clamp*
172-378: V-block with clamp*
 (max. workpiece dia.: 25mm)
172-197: Swivel center support*
 (max. workpiece dia.: 80mm)
176-305: Rotary stage with fine feed knob for
 505C/1010C/2010C models
176-306: Rotary stage with fine feed knob for
 2017C/3017C models

*Fixture mount adapter (**176-310**) is required for 1020B models.
 Fixture mount adapter (**176-304**) is required for 1720B/1730B models.



Refer to the MF /MF-U leaflet (E4153) for more details.

SPECIFICATIONS

Model No. (XY stage size)	505C	1010C	2010C	2017C	3017C	4020C
Order No.	MF-UA	176-667*	176-668*	176-669*	176-670*	176-671*
	MF-UB	176-687*	176-688*	176-689*	176-690*	176-691*
	MF-UC	176-673*	176-674*	176-675*	176-676*	176-677*
	MF-UD	176-693*	176-694*	176-695*	176-696*	176-697*
XY stage travel range	50 x 50mm	100 x 100mm	200 x 100mm	200 x 170mm	300 x 170mm	400 x 200mm
Z-axis travel range	150mm	150mm	150mm	220mm	220mm	220mm
Focusing method	Manual focusing (coarse focusing: 10mm/rev., fine focusing: 0.1mm/rev.)					
Measurement method	Linear encoder (2-axis model: X / Y-axis, 3-axis model: X / Y / Z-axis)					
Resolution (switchable)	0.001mm / 0.0005mm / 0.0001mm / .0001" / .00005" / .00001"					
Measuring accuracy (at 20°C)	XY-axis: (2.2+0.02L)μm, L = Measuring length (mm) when not loaded, JIS B 7153					
Indication accuracy (at 20°C)	Z-axis: (5+0.04L)μm, L = Measuring length (mm)					
Floating function	X and Y axes with Quick-release mechanism					
XY stage top size	280 x 280mm	280 x 280mm	350 x 280mm	410 x 342mm	510 x 342mm	610 x 342mm
Effective glass size	180 x 180mm	180 x 180mm	250 x 150mm	270 x 240mm	370 x 240mm	440 x 240mm
Swiveling function	—	—	—	±5° (left)	±5° (left)	±3° (left)
Max. stage loading	10kg	10kg	10kg	20kg	20kg	15kg
Max. workpiece height	150mm	150mm	150mm	220mm	220mm	220mm

* The following suffixes to the order No. (e.g.: **176-667-10**):

-10 for English User's Manual 11 for Chinese user's manual, No suffix is Japanese user's manual

Selection of machine type

Machine type	MF-UA	MF-UB	MF-UC	MF-UD
Observation type	Bright field (BF)	Bright field (BF)	Bright / Dark field (BF/DF)	Bright / Dark field (BF/DF)
Measurement system	X and Y-axis (2 axes)	X, Y and Z-axis (3 axes)	X and Y-axis (2 axes)	X, Y and Z-axis (3 axes)

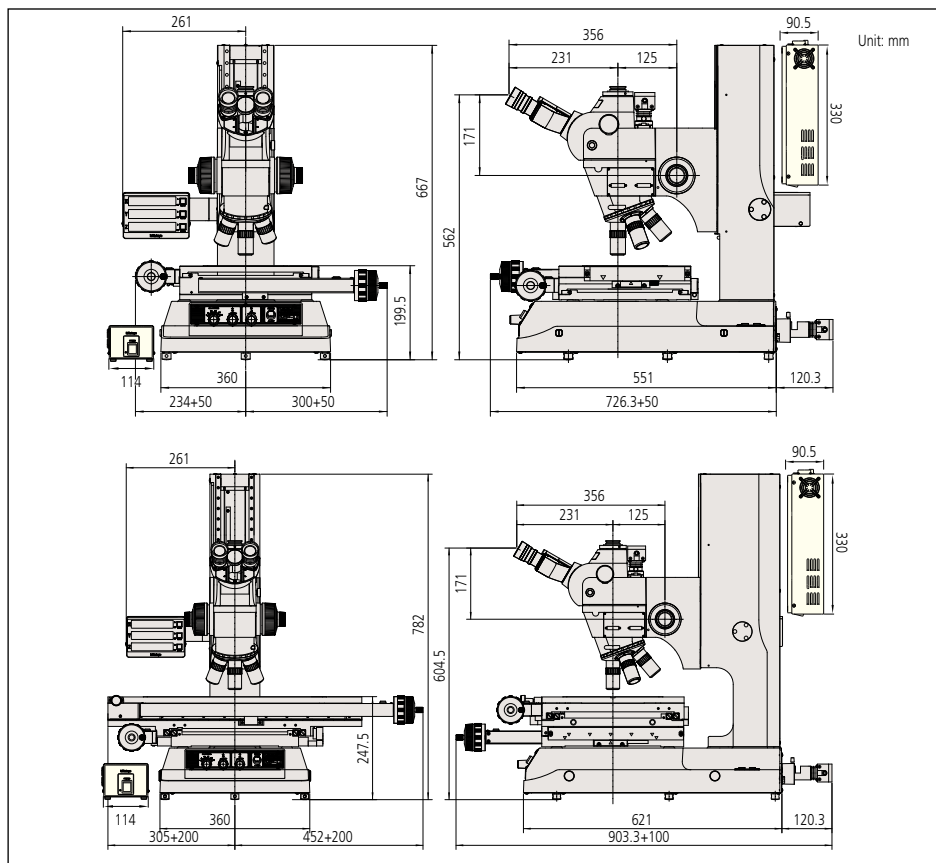
Illumination Unit

Applicable Illumination Unit	LED	Halogen
Order No.	176-346*	176-348*

Note: Because the "Generation C type" does not have equipped the illumination unit, it is necessary to select the either LED illumination unit or Halogen illumination unit.

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

DIMENSIONS



Hyper MF/MF-U

SERIES 176 — High-Accuracy Measuring Microscopes

FEATURES

- The world highest accuracy XY measuring accuracy of $(0.9+3L/1000)\mu\text{m}$
- Selectable LAF (Laser Auto Focus) function
- High operability and repeatability
- Three-axis motorized control
- Power-drive auto focus unit is a standard feature.

Hyper MF-U
with optional optical tube,
turret and objectives



SPECIFICATIONS

Model No.	Hyper MF-B2515B	Hyper MF-UB2515B	Hyper MF-UD2515B	Hyper MF-UE2515B	Hyper MF-UF2515B
Order No. (mm)	176-430*	176-431*	176-432*	176-433*	176-434*
Observation type	BF	BF	BF or BF/BD	BF	BF or BF/BD
Digital counter	—	—	—	—	—
Laser auto focus function	—	—	—	Available	Available
XY stage travel range	250 x 150mm	250 x 150mm	250 x 150mm	250 x 150mm	250 x 150mm
Measuring unit	Linear encoder	Linear encoder	Linear encoder	Linear encoder	Linear encoder
Resolution	0.01 μm	0.01 μm	0.01 μm	0.01 μm	0.01 μm
Measuring accuracy (at 20°C)	$(0.9+3L/1000)\mu\text{m}$, L = XY axis measuring length (mm) when not loaded				
Drive system (X, Y, Z-axis)	Motor-driver control with the joystick				
XY stage top size	460 x 350mm	460 x 350mm	460 x 350mm	460 x 350mm	460 x 350mm
Effective glass size	300 x 200mm	300 x 200mm	300 x 200mm	300 x 200mm	300 x 200mm
Swiveling function	$\pm 3^\circ$	$\pm 3^\circ$	$\pm 3^\circ$	$\pm 3^\circ$	$\pm 3^\circ$
Max. stage loading	30kg	30kg	30kg	30kg	30kg
Max. workpiece height	150mm	150mm	150mm	150mm	150mm

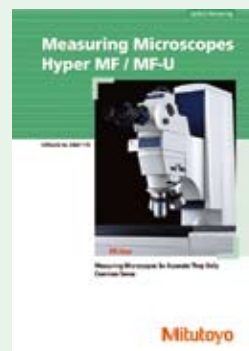
* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

Technical Data: Hyper MF

Observation image: Erect image
Optical tube: Monocular or binocular tube (optional, depression: 25°), Reticle projection method, with TV mount, Optical path ratio (eyepiece/TV mount: 50/50)
Eyepiece lens (optional): 10X, 15X, 20X
Objective: 3X (**375-037-1**), W.D.: 77.0mm
Optional: 1X, 5X 10X, 20X, 50X, 100X
Transmitted illumination
• Light source: Halogen bulb (12V, 100W) (fiber-optic cold light illumination)
• Optical system: Telecentric illumination with adjustable aperture diaphragms
• Functions: Light intensity adjustable, 100 steps brightness adjustment
Surface illumination
• Light source: Halogen bulb (12V, 50W)
• Optical system: Koehler illumination with adjustable aperture diaphragms
• Functions: Light intensity adjustable, 100 steps brightness adjustment
Data output: Via RS-232C interface
Power supply: 100/110/120/220/240V AC, 50/60Hz
Dimensions: 880x913x730mm (main unit)
160x476x381 (power unit)
Mass: 250kg (main unit), 14kg (power unit)

Technical Data: Hyper MF-U

Observation image: Erect image
Optical tube: Siedentoph type (pupil distance adjustment: 51 - 76mm), 1X tube lens, Binocular tube (depression: 25°), Reticle projection method, with TV mount, Optical path ratio (eyepiece/TV mount: 50/50)
Eyepiece lens: 10X (field No.: 24mm),
Optional: 15X, 20X
Turret (optional): Power
Objective (optional): M / BD Plan Apo objective from 1X to 100X (Refer to page J-36 for more details.)
Transmitted illumination
• Light source: Halogen bulb (12V, 100W)
• Optical system: Telecentric illumination with adjustable aperture diaphragms
• Functions: Light intensity adjustable, 100 steps brightness adjustment
Surface illumination
• Light source: Halogen bulb (12V, 50W)
• Optical system: Koehler illumination with adjustable aperture diaphragms
• Functions: Light intensity adjustable, 100 steps brightness adjustment
Data output: Via RS-232C interface
Power supply: 100/110/120/220/240V AC, 50/60Hz
Dimensions: 880x913x770mm (main unit)
160x476x381 (power unit)
Mass: 255kg (main unit), 14kg (power unit)



Refer to the Hyper MF/MF-U leaflet (E4267) for more details.

Optional Accessories

See page J-19 for Hyper MF models.
See page J-21 for Hyper MF-U models.

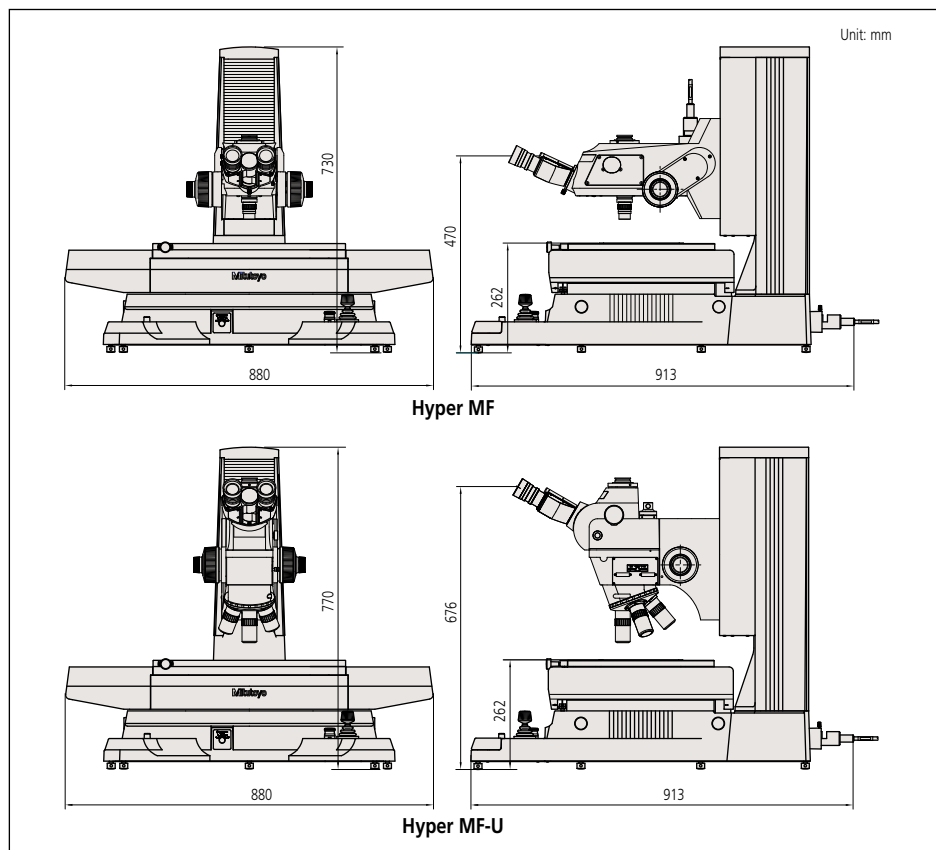


QM-Data200
2-D data processing unit
(Refer to page J-26 for more details.)



Vision Unit
PC-based vision measuring system
(Refer to page J-28 for more details.)

DIMENSIONS



Three-axis Motor-driven Joystick

The X, Y, and Z axes are driven and controlled with one joystick that serves as the nerve center of operation. Speed control is possible from high-speed traverse of the stage to ultra low-speed, precise positioning of a workpiece.



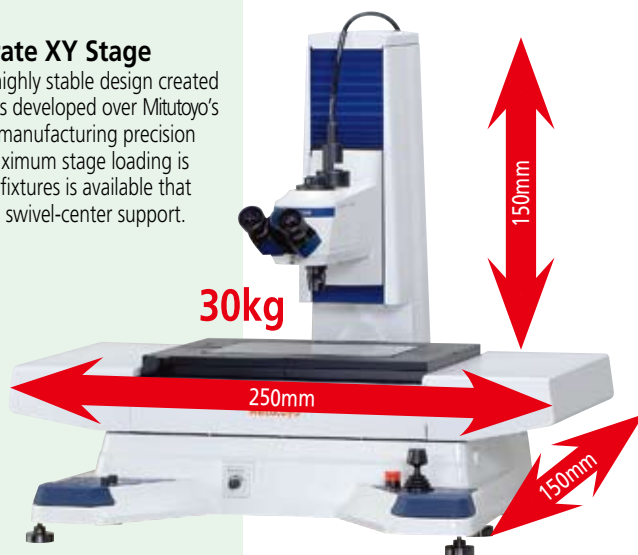
Highly Accurate Digital Scales

These microscopes are equipped with highly accurate digital glass scales on all three axes. Mitutoyo produces glass scales in an underground laboratory where the temperature and humidity are constant throughout the year. The XY (stage) and Z (optical tube) displacements are displayed digitally.



Large, Highly Accurate XY Stage

The XY stage is a massive, highly stable design created using mechanical techniques developed over Mitutoyo's long years of experience in manufacturing precision measuring microscopes. Maximum stage loading is 30kg and a range of useful fixtures is available that includes a wafer holder and swivel-center support.

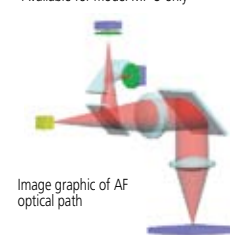


LAF Optical Tube

The LAF (Laser Auto Focus) optical tube can be selected. The LAF system achieves high repeatability when measuring minute steps, etc., enabling difficult measurements with minimum fatigue.



*Available for model MF-U only



The LAF uses a low-power laser that corresponds to Class 2 (visible radiation) of JIS C6802/1997, Safety of Laser Products.



Accessory for Measuring Microscope

Focus Pilot FP-05

FEATURES

- By installing this system on the camera mount of an MF series measuring microscope and projecting the focusing chart onto the workpiece surface, the focal point can be detected with high-accuracy and high-repeatability.
- The brightness of the chart can be adjusted.
- A wide view field observation on the monitor is made possible with the use of a CCD camera (C-mount adapter is included.)

- Four types of chart patterns are available. The pattern should be selected in accordance with the type of workpiece surface texture.



Concentric circle



Slit



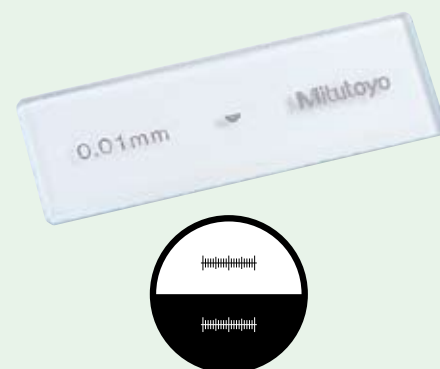
SPECIFICATIONS

Order No.	375-057*	375-058*	375-067*	375-068*
Applicable microscopes	MF C models		MF-U C models	
Light source	Green LED	Red LED	Green LED	Red LED
Magnification	0.5X, Accuracy: 0.1% **			
Camera adapter	C-mount (provided)			
Applicable CCD camera	Up to 2/3-inch			
Mass	1.8kg		1.8kg	

* To denote your AC power cable add the following suffixes to the order No.:
A for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK,
No suffix is required for JIS/100V
 ** Within 2/3 area from the center of view field



Stage Micrometer



SPECIFICATIONS

Order No.	375-056
Range	1mm
Graduations	0.01mm
Accuracy (at 20°C)	(1+L)μm, L = Measuring length (mm)
Dimensions (WxD)	76 x 26mm
Mass	16g

Power Focus Unit



SPECIFICATIONS

Order No.	Please contact us
Applicable microscopes	MF-C models, MF-UC models
Resolution	0.4μm
Drive speed	3.2mm/s
Power supply	100 - 240V AC, 50/60Hz
Dimensions (WxDxH)	Control box: 108 x 72 x 193mm

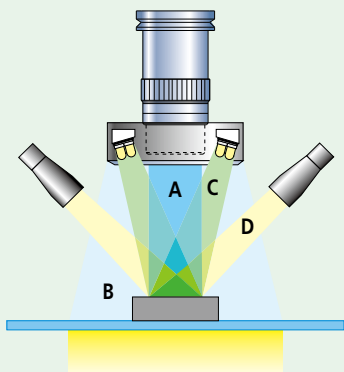
Manual and Power Turrets



SPECIFICATIONS

Order No.	176-211	378-018	176-210*	378-016*	378-116*
Observation type	BD	BF	BD	BF	BF
No. of objective mounts	4-mount	4-mount	4-mount	4-mount	5-mount
Driving method	Manual		Motor		
Power supply	—	—	AC100V - 240V		
Dimensions (W x D x H)	—	—	Turret: 164x65x137 Control Box: 108x72x193		

* To denote your AC line voltage add the following suffixes to the order No. (e.g.:
176-210A):
A for UL/CSA, **D** for CEE, **E** for BS, **DC** for China, **K** for EK, **C** for Taiwan, **No**
 suffix is required for JIS/100V



A: Vertical surface illumination (Halogen)



PCB



HDD suspension



IC circuit

B: Ring fiber-optics illumination



Flexible PCB



PCB



Electric parts

C: LED Ring Illumination



HDD suspension



PCB



Black resin molded parts

D: Twin fiber-optics illumination



IC package



Garnet



PCB

Twin fiber-optics illuminator



SPECIFICATIONS

Order No.	176-343*
Applicable microscopes	MF, MF-U models
Length of fiber cable	700mm
Light source	Halogen bulb (12V, 100W) (517181: halogen bulb)
Dimensions (W x D x H)	Light unit: 235 x 76 x 120mm

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

Ring fiber-optics illuminator



SPECIFICATIONS

Order No.	176-366*
Applicable microscopes	MF models
Length of fiber cable	1000mm
Light source	Halogen bulb (12V, 100W) (517181: halogen bulb)
Dimensions (W x D x H)	Light unit: 235 x 76 x 120mm

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

LED Ring Illuminator



SPECIFICATIONS

Order No.	176-367-2*
Applicable microscopes	MF models with 1X/3X/5X/10X objective
Light source	White LED
Length of LED cable	1500mm

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

LED Ring Light (for FS Objectives)



SPECIFICATIONS

Order No.	Please contact us
Applicable microscopes	MF models with 1X/3X/5X objective
Light source	Supplied from microscope (surface illumination)

QM-Data200

SERIES 264 — 2-D Data Processing Unit

The QM-Data200 is a geometric readout/analysis unit for optical instruments such as a profile projectors. This unit features powerful 2-D coordinate measurement capabilities with easy-to-use key operation. The QM-Data200 improves operator productivity, minimizes errors and saves total measurement time and production cost.

FEATURES

- Informative graphic displays on the large LCD screen make for easy measurement operations.
- One-key operation for combined measurements that are often used (circle-circle distance, etc.)
- The AI measurement function (automatic identification of measuring item) eliminates switching between the measurement command keys.

- Equipped with a measurement procedure teaching function and measuring position navigation in Repeat mode.
- The user menu function allows the user to register measurement commands or part programs to create custom menus.
- Tolerance zone measurement of data processing results and various statistical processing routines for each item are available.
- Measurement result output to "MS-Excel"* in spreadsheet (CSV) format.
- The measurement procedure and measurement result can be saved, using the optional floppy disk drive unit.
- Two models are available: a stand-alone type with tilt system and a flexible arm type that can be mounted on a Profile Projector.

* Microsoft Excel is a registered trademark of Microsoft Corporation.

Technical Data

Resolution:	0.0001mm
Program functions:	Part program creation, execution, editing
Statistical processing:	Number of data, maximum value, minimum value, mean value, standard deviation, range, histogram
Element memory:	Maximum of 1000 elements
Element recall:	Point, line, circle, distance, ellipse, rectangular hole, slotted hole, intersection and intersecting angle
Element key-in:	Point, line, circle
Display system:	Monographic LCD (320 x 240 dots, with LED back light)
Measurement result file output:	RS-232C output (CSV format, MUX-10F format)
Display language:	Japanese/English/German/French/Italian/Spanish/Portuguese/Chinese (simplified/traditional), Korean
Data input:	RS-232C, XYZ-axis signal, Footswitch
Data output:	RS-232C, Printer, Floppy disk drive unit
Power supply:	100V AC to 240V AC
Mass:	2.9kg (stand-mount type) 2.8kg (arm-mount type)

• Intuitive panel design

The QM-Data200 employs "Geometry Keys" to accelerate the measurement process. The probing routine of standard geometric features and combinations are designed with Geometry Keys on the front panel. Simply clicking a key and then capturing the feature coordinates means you can complete the measurement quickly and accurately. This improves operator productivity, reduces errors and save operation time and cost.



QM-Data200

No.: 264-145* (stand-mount type)

No.: 264-146* (arm-mount type)

No.: 264-149* (for Hyper MF / MF-U)

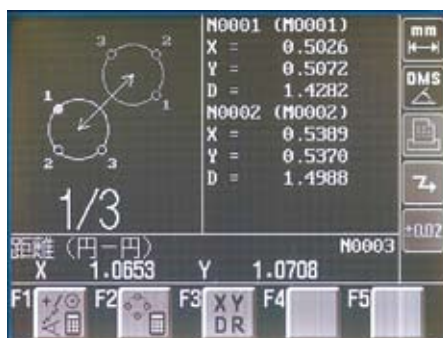
* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **E** for BS, **No suffix** is required for JIS/100V



QM-Data200
Stand-mount type

• Graphic display

Measurement information and data are visualized on the back-lit LCD display with graphical interfaces. The geometric feature that you selected is displayed with the probing navigator. The measurements map and blink indication show you the probing points and sequences. Simply probe points and click by following the blink indicator. Measurements can be easily completed even by a beginner. This improves operation accuracy and reduces errors and time.



Refer to the QM Data200 and Vision Unit leaflet (E4232) for more details.

Optional Accessories

- 12AAH035:** Floppy disk drive unit (USB type)
- 12AAD033:** Receipt printer (for 230V)
- 12AAD034:** Receipt printer (for 120V)
- 908353:** Printer paper for receipt printer
- 12AAA804:** Printer cable (2m)
- 937179T:** Foot switch
- 172-270:** Adjustable stand
- 12AAD193:** Connection cable B
- 12AAD194:** Connection cable C
- 12AAD195:** Connection cable D
- 12AAD196:** Connection cable E
- 12AAA807:** RS-232C cable (2m)
- 12AAG920:** RS-232C cable (3m)

Technical Data

Image detection

- Directivity: Non-direction
- Min. diameter: $\phi 2\text{mm}$ on the screen
- Min. width: 1mm on the screen
- Max. moving speed: 1000mm/s

Applicable illumination

- Type: Surface / Contour illumination
- Range: 30Lux to 1500Lux on the screen

Repeatability:

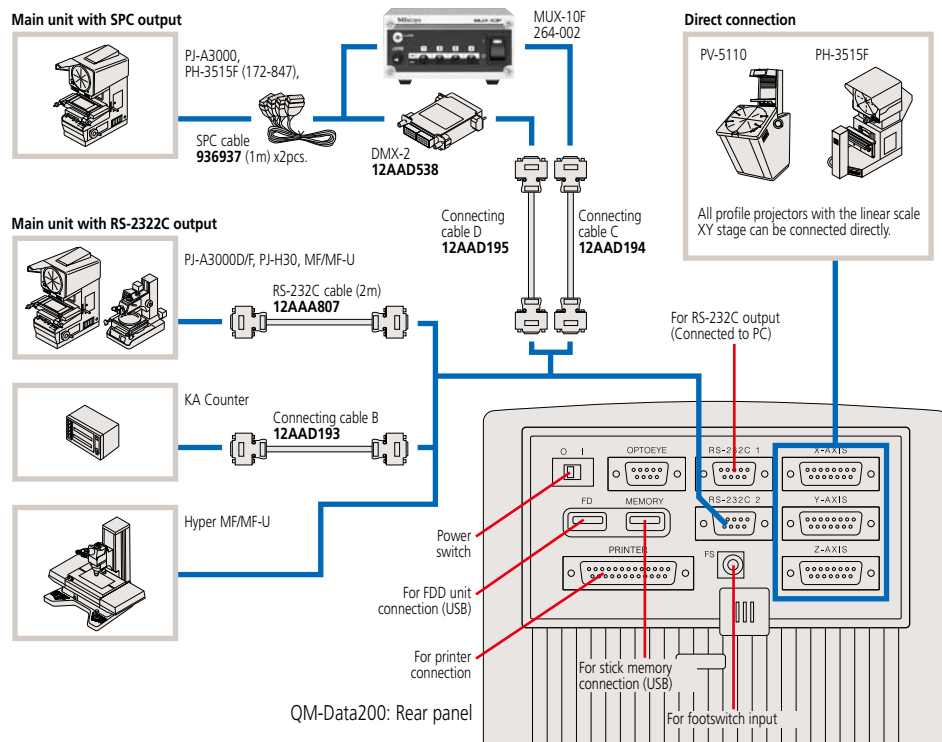
Function: 1 μm in contour illumination
Creating, performing, and editing measuring procedures

Optional Accessories

- 12AAE671:** Detector attachment A (for $\phi 250$ to $\phi 350\text{mm}$ screen of PJ-A3000, PJ-H30, PH-3515, series)
- 12AAE672:** Detector attachment B (for $\phi 500$ to $\phi 600\text{mm}$ screen of PV-5110, PV-600A series)



SYSTEM DIAGRAM



OPTOEYE-200: No. 332-151

The OPTOEYE-200 Image Edge Sensor eliminates human errors which may be involved in visual alignment, ensuring speedy, accurate, and consistent measurements, regardless of operator's skill.

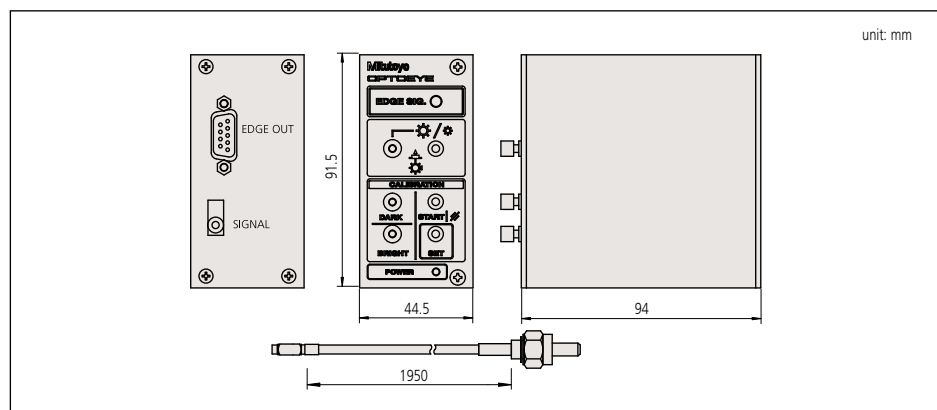
FEATURES

- OPTOEYE-200 adopts a thin fiber-optic cable for detector connection to offer easy set-up and smart operation without obstructing your vision.

- Bright and dark buttons allow easy calibration.
- OPTOEYE can be powered by QM-Data200 via the connecting cable. It means that no AC adapter is required.



DIMENSIONS



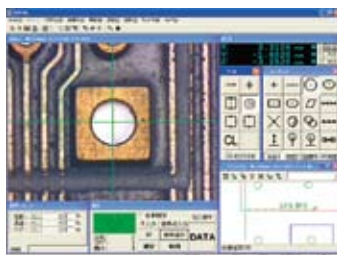
Vision Unit

SERIES 359 — Vision System Retrofit for Microscopes

FEATURES

- The automatic edge-detection tools and various macro icons allow measurement in one easy step.
- The graphics and measurement navigation functions facilitate operation.
- Image data input/storage function.
- Measurement results are output to MS-Excel®. This lets the user generate an inspection table on the same computer.
- Allows the tolerance zone measurement of measurement results and various types of statistical processing for each item.
- Combined use with the focus pilot provides high-accuracy in height measurements. (Patent pending)
- A series of measuring operations can be performed using just one screen display.
- The auto-brightness control function faithfully reproduces the type and degree of illumination used. (This function is limited to the MF/MF-U series.)

QSPAK Measurement Window



Vision Unit
No.: 359-737 (for MF C)
No.: 359-739 (for MF-UC)

The PC system, QSPAK software and microscope are optional.

Technical Data

Projected image:	Inverted image
Camera unit	
• Image sensor:	1/2" color CMOS camera
• Resolution:	0.0001mm
• Dimensions:	100 x 58 x 89mm (W x D x H)
• Mass:	0.4kg
Adapter unit	
• Operating software:	QSPAK VUE (optional)
• Dimensions:	45 x 123mm
• Magnification:	0.5X
• Mass:	0.3kg
Magnifications:	21X - 210X on 19" monitor
Standard accessory:	Foot switch (12AAJ088)

QSPAK, optional software

For observation/comparison of form

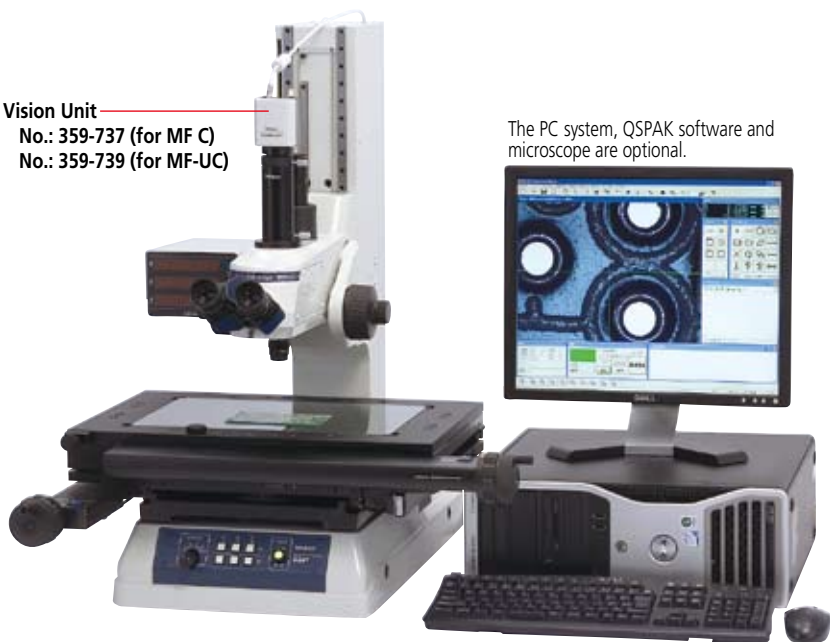
- Template matching function
- Manual pattern matching function

For simple measurement

- One-click edge detection tool function
- Smart tool function
- User macro function

For repeated measurement/auto-measurement

- Quick navigation function
- Playback function
- Graphic function
- External data output function
- Statistical calculation function



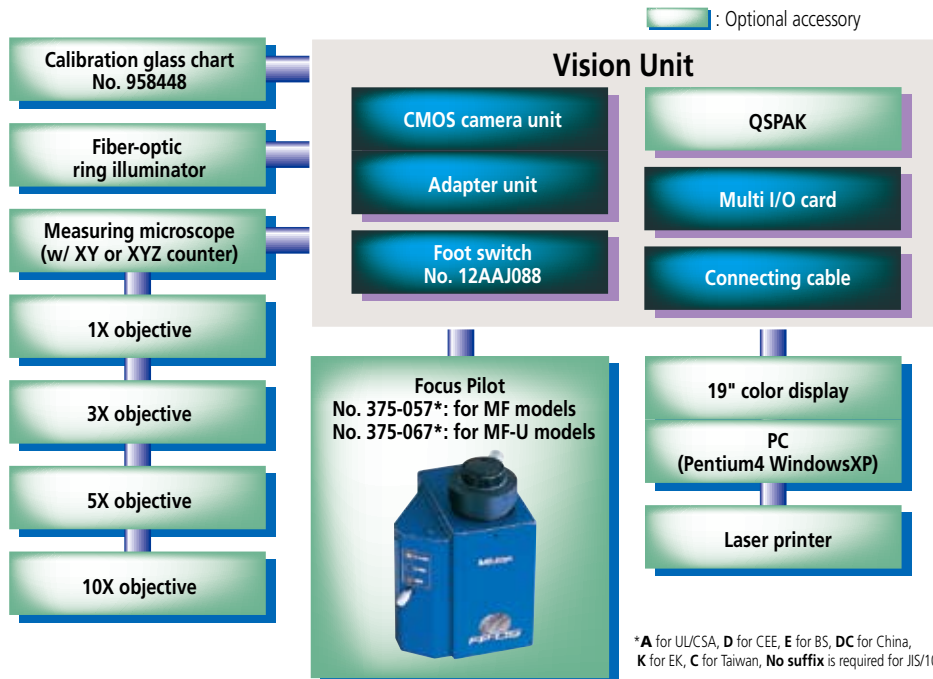
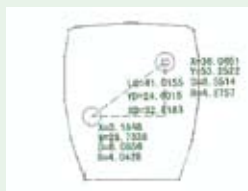
One-click Edge Detection

Just by clicking the mouse near the edge of a workpiece, QSPAK automatically scans the edge and detects it, showing its coordinates. This function also works with the point tool, box tool, circle tool and auto-focus tool.



Graphic Window

The measurement results and measured elements are plotted in the graphic window in real-time. By using this function the user can check the current measuring position at a glance. The graphic window can be used for geometrical calculation.



*A for UL/CSA, D for CEE, E for BS, DC for China,
K for EK, C for Taiwan, No suffix is required for JIS/100\

FS-300

SERIES 378 — High Power Inspection Microscope

The FS-300 is designed for inspecting micro-components such as IC chips and video head parts. The optical system features ultra-long working distance objectives, wide view field eyepieces, and independent correction for lateral chromatic aberration.

FEATURES

- The complete FS-300 system can be composed of a variety of components for meeting diverse applications.
- Available with or without a transmitted-light illuminator.
- Ultra-long working distance objectives provide easy manipulation of workpieces.
- Easy switching between bright-field illumination and dark-field illumination.
- Optional accessories widen the range of applications.



FS-300 with optional accessories

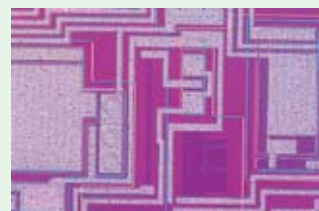
SPECIFICATIONS

Main unit	Observation system	Bright field (BF): 378-320, 378-322, 378-324, 378-326 Bright/dark field (BF/DF): 378-321, 378-323, 378-325, 378-327
	Reflected illumination	Koehler illumination with aperture diaphragm (centering mechanism) and field stop 12V/100W halogen lamp (non-stepped brightness adjustment) With filter mounting slot (2-slot) with BF/DF switching slide (378-321, 378-323, 378-325, 378-327 only)
	Transmitted illumination	12V/100W fiber illumination (non-stepped brightness adjustment) with aperture diaphragm (378-323, 378-324, 378-326, 378-327 only)
	Focus adjustment	With concentric coarse and fine focusing wheels (right and left) Fine adjustment: 0.1mm/rev. for 32mm travel range Coarse adjustment: 3.8mm/rev. for 32mm travel range
Power turret		Inward type with 4 lens mounts
Workstage		Travel stroke: 356 x 306mm with X-Y-axis fine feed knobs and coarse travel handle
Optical tube	Type	Trinocular tube (erect image)
	Field number	24
	Depression angle	Fixed 20°: 378-320, 378-321, 378-322, 378-323 Adjustable 0° to 20°: 378-324, 378-325, 378-326, 378-327
	Intermediate image mag.	1X
	Optical pass ratio	Siedentopf type, adjustment range: 51 - 76mm
	Pupil distance	Siedentopf type, adjustment range: 51 - 76mm
Eyepiece	Field of view	10X/ø30: 378-320, 378-321, 378-322, 378-323 10X/ø24: 378-324, 378-325, 378-326, 378-327
Applicable objective (optional)		M Plan Apo, M Plan Apo SL, G Plan Apo: 378-320, 378-322, 378-324, 378-326 BD Plan Apo, BD Plan Apo SL: 378-321, 378-323, 378-325, 378-327
Dimensions	Main unit	360 x 803 x 568.5mm
	Workstage	700 x 400mm
Power supply		100 to 240VAC, 50/60Hz
Power consumption		Approx. 150W: 378-320, 378-321, 378-324, 378-325 Approx. 300W: 378-322, 378-323, 378-326, 378-327
Mass		Approx. 50kg including workstage



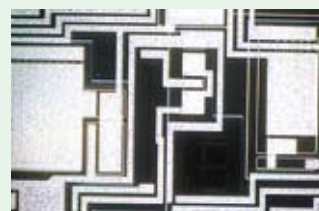
Polarized light observation:

Observing only the filtered light that vibrates in one direction. Used for observing materials with special optical characteristics, such as mineral and liquid crystal.



Differential interference observation:

Effective in detecting fine scratches and steps on the surface of metal, liquid crystal, and semiconductors.



Dark field observation:

Observing only the scattered light by shutting down the direct light to the objectives. The scratches and dust that cannot be viewed in the bright view field can be observed by this method in high-contrast.



Bright field observation:

Most common method of observation. Observing directly the light reflected from the surface of the workpiece..



Refer to the FS300 leaflet (E4197) for more details.

FS-70

SERIES 378 — Microscope Unit for Semiconductor Inspection

Technical Data

Focus adjustment	
• Method:	With concentric coarse and fine focusing wheels (right and left)
• Range:	50mm travel range 0.1mm/rev. for fine adjustment, 3.8mm/rev. for coarse adjustment
Trinocular tube Image:	Erect image
Pupil distance:	Siedentopf type, adjustment range: 51 - 76mm
Field number:	24
Tilt angle:	0° - 20° (only -TH, -THS models)
Illumination system:	Reflective illumination for bright field (Koehler illumination, with aperture diaphragm)
Light source:	12V100W fiber-optics, non-stepped adjustment, light guide length 1.5m, power consumption 150W
Objectives (optional):	M Plan Apo, M Plan Apo SL, G Plan Apo

FEATURES

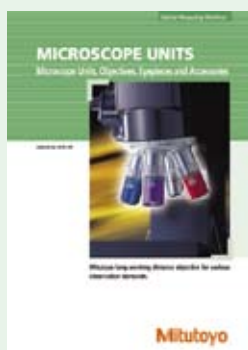
- The optical system that was originally developed for the best-selling FS60 models was further enhanced for the FS70 models. It is ideal as the microscope unit of a prober station for semiconductors. (All models CE marked.)
- The FS70L supports three types of YAG laser wavelength ranges (1064nm, 532nm and 355nm), while the FS70L4 supports two types of wavelength ranges (532nm and 266nm), thus expanding the scope of laser applications, allowing laser-cutting of thin-films used in semiconductors and liquid crystal substrates. However, Mitutoyo assumes no responsibility whatever for the performance and/or safety of the laser system used with Mitutoyo microscopes. A careful examination is recommended in selecting a laser-emission unit.
- Bright field, Differential Interference Contrast (DIC) and polarized observations are standard with the FS70Z. The FS70L and FS70L4 do not support the DIC method.
- By employing an inward turret, the long working distance objectives provide excellent operability.
- An ergonomic design with superb operability: the FS70 employs the erect-image optical system (the image in the field of view has the same orientation as the specimen) and enlarged fine focus adjustment wheel with rubber grip coarse-adjustment knob.



SPECIFICATIONS

Model No.	FS70	FS70-TH	FS70Z	FS70Z-TH	FS70L	FS70L-TH	FS70L4	FS70L4-TH
Order No.	378-184-1	378-184-3	378-185-1	378-185-3	378-186-1	378-186-3	378-187-1	378-187-3
Short base model No.	FS70-S	FS70-THS	FS70Z-S	FS70Z-THS	FS70L-S	FS70L-THS	FS70L4-S	FS70L4-THS
Order No.	378-184-2	378-184-4	378-185-2	378-185-4	378-186-2	378-186-4	378-187-2	378-187-4
Focus adjustment	50mm travel range with concentric coarse (3.8mm/rev) and fine (0.1mm/rev) focusing wheels (right / left)							
Image	Erect image							
Pupil distance	Siedentopf type, adjustment range: 51 - 76mm							
Field number	24							
Tilt angle	—	0° - 20°	—	0° - 20°	—	0° - 20°	—	0° - 20°
Optical pass ratio	50/50	100/0 or 0/100	50/50	100/0 or 0/100	100/0 or 0/100		100/0 or 0/100	
Protective filter	—		—		Built-in laser beam filter		Built-in laser beam filter	
Tube lens	1X		1X - 2X zoom		1X		1X	
Applicable laser	—		—		1064/532/355nm		532/266nm	
Camera mount	C-mount (using optional adapter B)				Use a laser with TV port.		C-mount receptacle (with green filter switch)	
Illumination system, optional	Reflective illumination for bright field (Koehler illumination, with aperture diaphragm) 12V 100W fiber-optics, non-stepped adjustment, light guide length: 1.5m, power consumption 150W							
Objective, optional (for observation)	M Plan Apo, M Plan Apo SL, G Plan Apo							
Objective, optional (for laser-cutting)	—				M/LCD Plan NIR, M/LCD Plan NUV		M Plan UV	
Loading*	14.5kg	13.6kg	14.1kg	13.2kg	14.2kg	13.5kg	13.9kg	13.1kg
Mass (main unit)	6.1ka	7.1ka	6.6ka	7.5ka	6.4ka	7.2ka	6.7ka	7.5ka

*Loading on optical tube excluding weight of objective lenses and eyepieces



Refer to the Microscope Units leaflet (E4191) for more details.

VMU

SERIES 378 — Video Microscope Unit

The VMU is a compact, lightweight, and easy-to-install microscope unit for CCD camera monitoring in semiconductor fabrication facilities.

FEATURES

- The optical system features ultra-long working distance objectives and correction for the wide range of radiation wavelengths in use.
- The fiber-optic reflected illumination keeps the workpiece free from thermal expansion. The fiber-optic illuminator is required for the light source.
- Also available with a laser mount or turret (objective mount).



SPECIFICATIONS

Magnification of tube	1X
Applicable wavelength	378-505, 378-506 Near-infrared and visible radiation
	378-513 Near-infrared—visible—near-ultraviolet radiation
	378-514 Visible and ultraviolet radiation
Objective	(Optional)
Reflected illumination	• Telecentric system with aperture stop system • Fiber-optic illuminator (optional) is required.
Light source	Halogen bulb (21V, 150W) (optional)
Mass	378-505: 570g 378-506: 590g 378-513: 1270g 378-514: 1300g

Selection Guide to System Configuration

Order No. (Depends on each system configuration)	378-505	378-506	378-513	378-514
Vertical CCD camera mount	●	●	●	●
Horizontal CCD camera mount		●		
YAG laser mount			●	●
Fiber-optic illumination unit			●	●
M Plan Apo, M Plan Apo SL, G Plan Apo objectives for bright field observation	▲	▲	▲	▲
M Plan Apo NIR, LCD Plan Apo NIR, M Plan Apo NUV and LCD Plan Apo NUV objectives for laser cutting			▲	
M Plan UV objectives for laser machining				▲

●: Provided, ▲: Available as optional accessory



Refer to the Microscope Units leaflet (E4191) for more details.

Eyepieces

SERIES 378

FEATURES

- The field of view is extra wide.
- Optional reticles are available.

Reticles (optional)

- 516848:** Cross-hair
516576: Broken cross hair (90° and 60°)
516578: Concentric circle
 (Diametric increment: 1.2mm)
516577: 20mm scale
 (Minimum reading: 0.1mm) with cross hair
516849: 10mm scale (Minimum reading: 0.1mm)
516850: 5mm scale (Minimum reading: 0.05mm)
516851: 10x10mm section
 (Minimum section: 1x1mm)



SPECIFICATIONS

Order No. (2pcs. set)	Magnifi- cation	Field number	Mass	Individual order No.
378-856	10X	24	85g	378-856-5
378-857	15X	16	40g	378-857-5
378-858	20X	12	55g	378-858-8

Objectives

SERIES 378

The Mitutoyo 378 Series objectives have the world's longest working distance and an infinity correction optical system. These objectives provide flexible observation at high magnifications and independent correction of chromatic aberration.

FEATURES

- The long working distance type objectives provide excellent clearance between the lens surface and the workpiece surface in focus, making it possible to observe workpieces which are usually hard-to-focus because of awkward projections.

- The metallurgical plan apochromatic (M Plan Apo) objective is an excellent optical system. This objective provides a flat, chromatic aberration-free image throughout the field of view, making it is suitable for any type of microscope.
- Specially designed objectives are also available with correction for near-infrared radiation, near-ultraviolet radiation, and ultraviolet radiation, or various thicknesses of LCD screen glasses.
- The mounting screw threads of objectives are designed to conform to JIS B-7141-1988.



Refer to the Microscope Units leaflet (E4191) for more details.



M Plan Apo and M Plan Apo SL objectives for bright field observation



BD Plan Apo and BD Plan Apo SL objectives for bright/dark field observation



Near-infrared radiation corrected M Plan Apo NIR objectives



Near-ultraviolet radiation corrected M Plan Apo NUV objectives



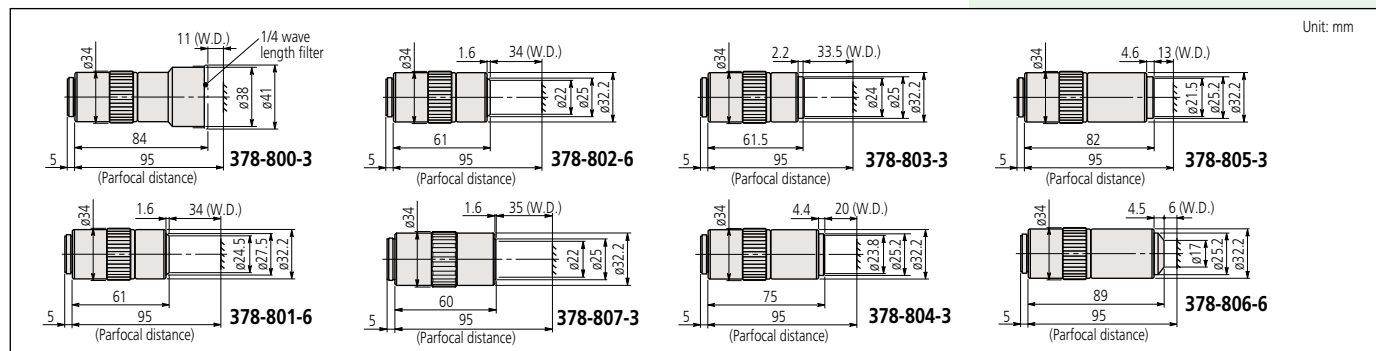
Ultraviolet radiation corrected M Plan UV objectives

M Plan Apo for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-800-3	1X	0.025	11.0mm	200mm	11.0μm	440μm	ø24mm	4.8x6.4mm	300g
378-801-6	2X	0.055	34.0mm	100mm	5.0μm	91μm	ø12mm	2.4x3.2mm	220g
378-802-6	5X	0.14	34.0mm	40mm	2.0μm	14.0μm	ø4.8mm	0.96x1.28mm	240g
378-807-3	7.5X	0.21	35.0mm	26.67mm	1.3μm	6.2μm	ø3.6mm	0.64x0.85mm	240g
378-803-3	10X	0.28	33.5mm	20mm	1.0μm	3.5μm	ø2.4mm	0.48x0.64mm	230g
378-804-3	20X	0.42	20.0mm	10mm	0.7μm	1.6μm	ø1.2mm	0.24x0.32mm	270g
378-805-3	50X	0.55	13.0mm	4mm	0.5μm	0.9μm	ø0.48mm	0.10x0.13mm	290g
378-806-3	100X	0.70	6.0mm	2mm	0.4μm	0.6μm	ø0.24mm	0.05x0.06mm	320g

Note:
Polarizing unit (378-074) is required when using 1X objective.

DIMENSIONS

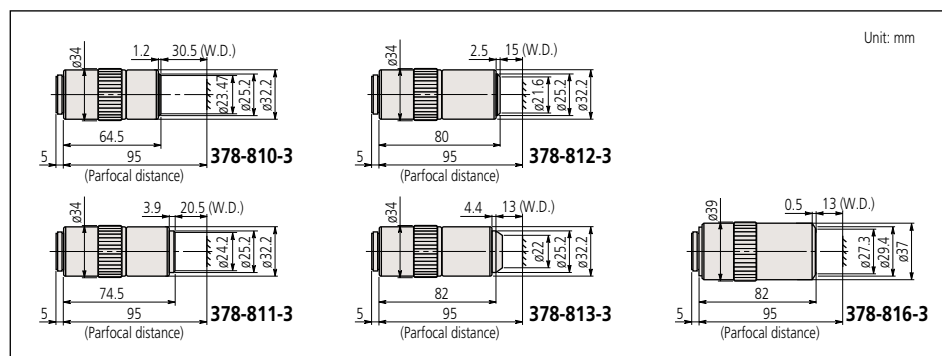


M Plan Apo SL for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-810-3	20X	0.28	30.5mm	10mm	1.0μm	3.5μm	ø1.2mm	0.24x0.32mm	240g
378-811-3	50X	0.42	20.5mm	4mm	0.7μm	1.6μm	ø0.48mm	0.10x0.13mm	280g
378-812-3	80X	0.50	15.0mm	2.5mm	0.6μm	1.1μm	ø0.3mm	0.06x0.08mm	280g
378-813-3	100X	0.55	13.0mm	2mm	0.5μm	0.9μm	ø0.24mm	0.05x0.06mm	290g
378-816-3	200X	0.62	13.0mm	1mm	0.4μm	0.7μm	ø0.12mm	0.025x0.03mm	490g

Note:
These objectives offer extra-long working distance.

DIMENSIONS

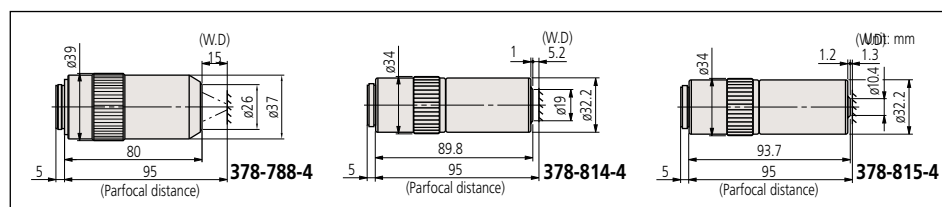


M Plan Apo HR for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-788-4	10X	0.42	15mm	20mm	0.7μm	1.6μm	ø2.4mm	0.48x0.64mm	460g
378-814-4	50X	0.75	5.2mm	4mm	0.4μm	0.49μm	ø0.48mm	0.10x0.13mm	400g
378-815-4	100X	0.90	1.3mm	2mm	0.3μm	0.34μm	ø0.24mm	0.05x0.06mm	410g

Note:
These objectives offer extra-high resolving power.

DIMENSIONS



Mag.: Magnification
N.A.: Numerical aperture
W.D.: Working distance
f: Focal distance
R: Resolving power
D.F.: Focal depth
View field 1: Field of view when using ø24mm eyepiece
View field 2: Field of view when using 1/2" CCD camera

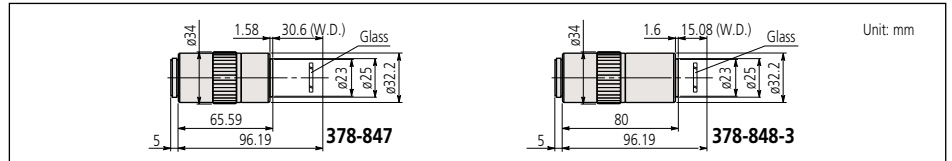
Note:
The G Plan Apo Series are designed for observing a
workpiece through glass (thickness = 3.5mm).

Glass Thickness (t = 3.5mm) Corrected G Plan Apo for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-847	20X	0.28	29.42mm*	10mm	1.0μm	3.5μm	ø1.2mm	0.24x0.32mm	270g
378-848-3	50X	0.50	13.89mm*	4mm	0.6μm	1.1μm	ø0.48mm	0.10x0.13mm	320g

*In air

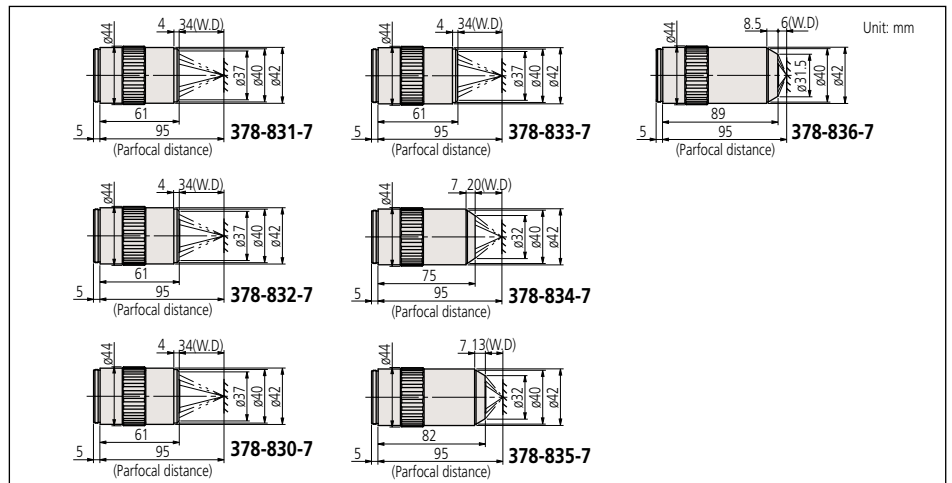
DIMENSIONS



BD Plan Apo for Bright/Dark Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-831-7	2X	0.055	34.0mm	100mm	5.0μm	91μm	ø12mm	2.4x3.2mm	340g
378-832-7	5X	0.14	34.0mm	40mm	2.0μm	14.0μm	ø4.8mm	0.96x1.28mm	350g
378-830-7	7.5X	0.21	34.0mm	26.67mm	1.3μm	6.2μm	ø3.6mm	0.64x0.85mm	350g
378-833-7	10X	0.28	34.0mm	20mm	1.0μm	3.5μm	ø2.4mm	0.48x0.64mm	350g
378-834-7	20X	0.42	20.0mm	10mm	0.7μm	1.6μm	ø1.2mm	0.24x0.32mm	400g
378-835-7	50X	0.55	13.0mm	4mm	0.5μm	0.9μm	ø0.48mm	0.10x0.13mm	440g
378-836-7	100X	0.70	6.0mm	2mm	0.4μm	0.6μm	ø0.24mm	0.05x0.06mm	460g

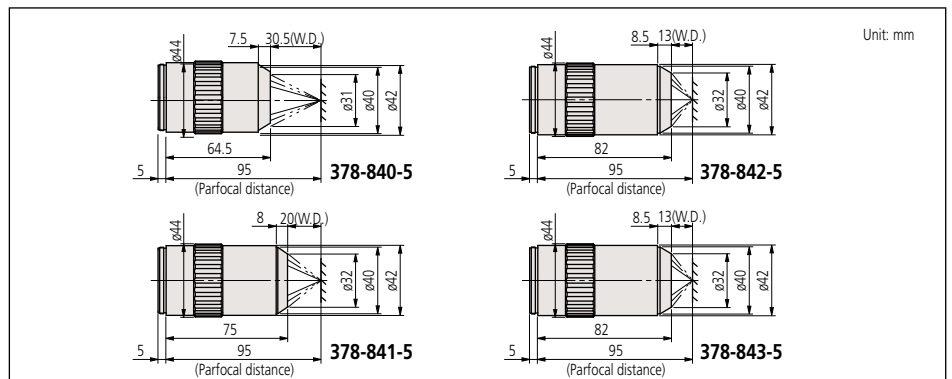
DIMENSIONS



BD Plan Apo SL for Bright/Dark Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-840-7	20X	0.28	30.5mm	10mm	1.0μm	3.5μm	ø1.2mm	0.24x0.32mm	350g
378-841-7	50X	0.42	20.0mm	4mm	0.7μm	1.6μm	ø0.48mm	0.10x0.13mm	410g
378-842-7	80X	0.50	13.0mm	2.5mm	0.6μm	1.1μm	ø0.3mm	0.06x0.08mm	430g
378-843-7	100X	0.55	13.0mm	2mm	0.5μm	0.9μm	ø0.24mm	0.05x0.06mm	440g

DIMENSIONS



Note:
These objectives offer extra-long working distance.

Mag.: Magnification
N.A.: Numerical aperture
W.D.: Working distance
f: Focal distance
R: Resolving power
D.F.: Focal depth
View field 1: Field of view when using ø24mm eyepiece
View field 2: Field of view when using 1/2" CCD camera

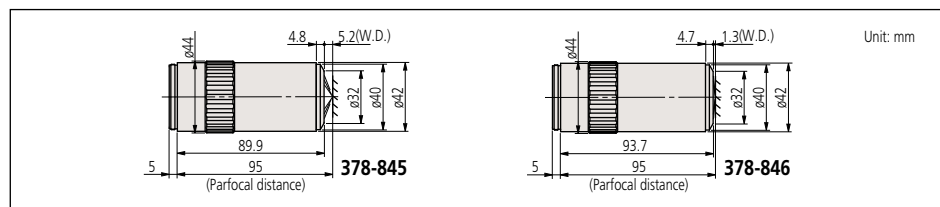
BD Plan Apo HR for Bright/Dark Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-845-7	50X	0.75	5.2mm	4mm	0.4μm	0.49μm	ø0.48mm	0.10x0.13mm	530g
378-846-7	100X	0.90	1.3mm	2mm	0.3μm	0.34μm	ø0.24mm	0.05x0.06mm	545g

Note:

These objectives offer extra-high resolving power.

DIMENSIONS



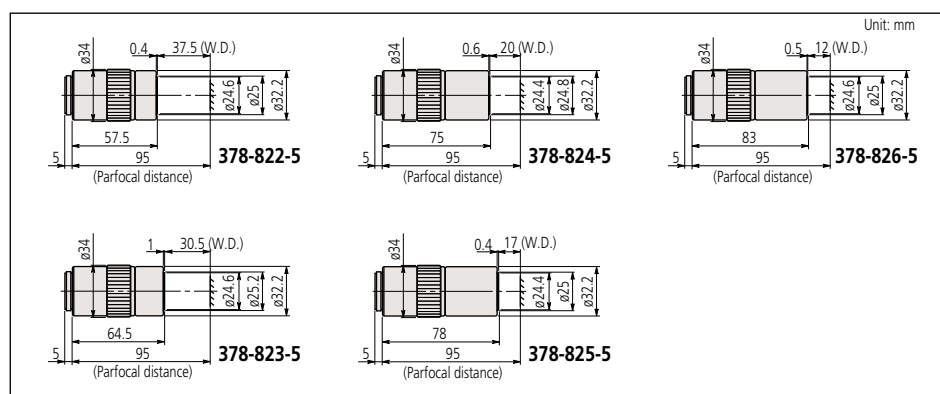
Near-infrared Radiation Corrected M Plan Apo NIR for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-822-5	5X	0.14	37.5mm	40mm	2.0μm	14.0μm	ø4.8mm	0.96x1.28mm	220g
378-823-5	10X	0.26	30.5mm	20mm	1.1μm	4.1μm	ø2.4mm	0.48x0.64mm	250g
378-824-5	20X	0.40	20.0mm	10mm	0.7μm	1.7μm	ø1.2mm	0.24x0.32mm	300g
378-825-5	50X	0.42	17.0mm	4mm	0.7μm	1.6μm	ø0.48mm	0.10x0.13mm	315g
378-826-5	100X	0.50	12.0mm	2mm	0.6μm	1.1μm	ø0.24mm	0.05x0.06mm	335g
378-863-5	50X	0.65	10mm	4mm	0.42μm	0.65μm	ø0.48mm	0.10x0.13mm	450g
378-864-5	100X	0.70	10mm	2mm	0.39μm	0.56μm	ø0.24mm	0.05x0.06mm	450g

Note:

These objectives are designed so that a workpiece's image can be focused within the focal depth even when the wavelength used is changed anywhere from the visible range (λ = 480nm) up to near-infrared range (λ = 1800nm). Therefore the M Plan NIR Series are suitable for laser repair. However, when the wavelength used exceeds 1100nm, the focussing position may slightly deviate from that in the visible range due to changes in glass dispersion and refractive index.

DIMENSIONS



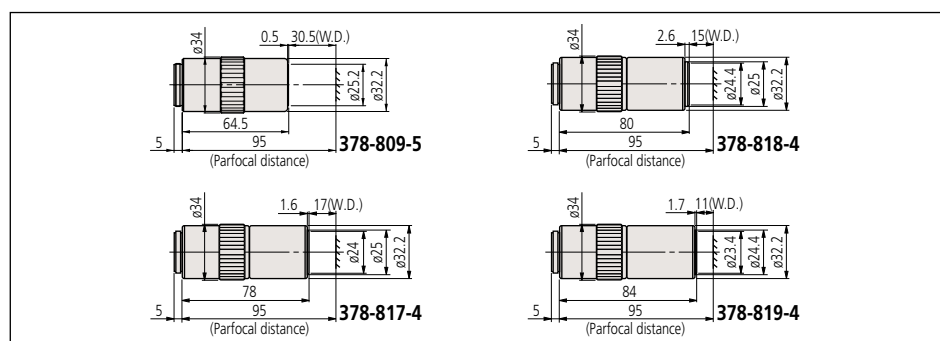
Near-ultraviolet Radiation Corrected M Plan Apo NUV for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	-
378-809-5	10X	0.28	30.5mm	20mm	1μm	3.5μm	ø2.4mm	0.48x0.64mm	255g
378-817-4	20X	0.40	17.0mm	10mm	0.7μm	1.7μm	ø1.2mm	0.24x0.32mm	340g
378-818-4	50X	0.42	15.0mm	4mm	0.7μm	1.6μm	ø0.48mm	0.10x0.13mm	350g
378-819-4	100X	0.50	11.0mm	2mm	0.6μm	1.1μm	ø0.24mm	0.05x0.06mm	380g
378-888-4	50X	0.65	10.00mm	4mm	0.42μm	0.65μm	ø0.48mm	0.10x0.13mm	500g

Note:

These objectives are designed so that a workpiece's image can be focused within the focal depth even when the wavelength used is changed anywhere from the visible range (λ = 620nm) to the near-ultraviolet range (λ = 355nm). Therefore The M Plan NUV Series are suitable for laser repair using a high frequency laser beam.

DIMENSIONS



Mag.: Magnification
N.A.: Numerical aperture
W.D.: Working distance
f: Focal distance
R: Resolving power
D.F.: Focal depth
View field 1: Field of view when using ø24mm eyepiece
View field 2: Field of view when using 1/2" CCD camera

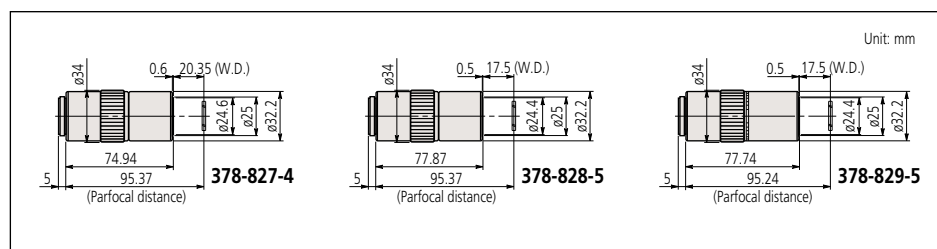
Note:
These near-infrared ($\lambda = 1800\text{nm}$) corrected objectives are designed for observing a workpiece through LCD glass (thickness = 1.1mm (**378-827-4**, **378-828-5**) or 0.7mm (**378-829-5**, **378-754-5**)) and for laser repair.

Near-Infrared Radiation and LCD Glass Thickness ($t = 1.1\text{mm}$ or 0.7mm) Corrected LCD Plan Apo NIR for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-827-5	20X	0.40	19.98mm*	10mm	$0.7\mu\text{m}$	$1.7\mu\text{m}$	$\phi 1.2\text{mm}$	$0.24 \times 0.32\text{mm}$	305g
378-828-5	50X	0.42	17.13mm*	3.9mm	$0.7\mu\text{m}$	$1.6\mu\text{m}$	$\phi 0.48\text{mm}$	$0.10 \times 0.13\text{mm}$	320g
378-829-5	50X	0.42	17.26mm*	3.9mm	$0.7\mu\text{m}$	$1.6\mu\text{m}$	$\phi 0.48\text{mm}$	$0.10 \times 0.13\text{mm}$	320g
378-752-5	100X	0.50	12.13mm*	2mm	$0.6\mu\text{m}$	$1.1\mu\text{m}$	$\phi 0.24\text{mm}$	$0.05 \times 0.06\text{mm}$	335g
378-754-5	100X	0.50	11.76mm*	2mm	$0.6\mu\text{m}$	$1.1\mu\text{m}$	$\phi 0.24\text{mm}$	$0.05 \times 0.06\text{mm}$	335g

*In air

DIMENSIONS



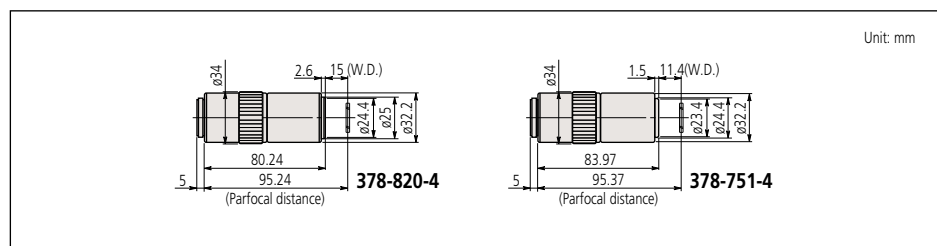
Note:
These near-infrared ($\lambda = 1800\text{nm}$) corrected objectives are designed for observing a workpiece through LCD glass (thickness = 1.1mm (**378-827-4**, **378-828-5**) or 0.7mm (**378-829-5**, **378-754-5**)) and for laser repair.

Near-ultraviolet Radiation and LCD Glass Thickness ($t = 0.7\text{mm}$) Corrected LCD Plan Apo NUV for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-820-4	50X	0.42	14.76mm*	4mm	$0.7\mu\text{m}$	$1.6\mu\text{m}$	$\phi 0.48\text{mm}$	$0.10 \times 0.13\text{mm}$	310g
378-753-4	50X	0.42	14.53mm	4mm	$0.7\mu\text{m}$	$1.6\mu\text{m}$	$\phi 0.48\text{mm}$	$0.10 \times 0.13\text{mm}$	310g
378-751-4	100X	0.50	11.03mm	2mm	$0.6\mu\text{m}$	$1.1\mu\text{m}$	$\phi 0.24\text{mm}$	$0.05 \times 0.06\text{mm}$	380g

*In air

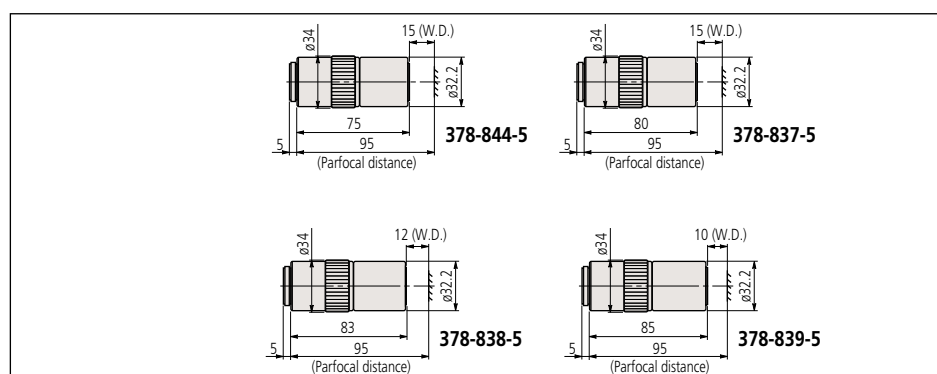
DIMENSIONS



Ultraviolet Radiation Corrected M Plan UV for Bright Field Observation

Order No.	Mag.	N.A.	W.D.	f	R	D.F.	View field 1	View field 2	Mass
378-844-5	10X	0.25	20mm	20mm	$1.1\mu\text{m}$	$4.4\mu\text{m}$	$\phi 2.4\text{mm}$	$0.48 \times 0.64\text{mm}$	310g
378-837-5	20X	0.36	15.0mm	10mm	$0.8\mu\text{m}$	$2.1\mu\text{m}$	$\phi 1.2\text{mm}$	$0.24 \times 0.32\text{mm}$	330g
378-838-5	50X	0.40	12.0mm	4mm	$0.7\mu\text{m}$	$1.7\mu\text{m}$	$\phi 0.48\text{mm}$	$0.10 \times 0.13\text{mm}$	400g
378-839-5	80X	0.55	10.0mm	2.5mm	$0.5\mu\text{m}$	$0.9\mu\text{m}$	$\phi 0.3\text{mm}$	$0.06 \times 0.08\text{mm}$	380g

DIMENSIONS



Mag.: Magnification
N.A.: Numerical aperture
W.D.: Working distance
f: Focal distance
R: Resolving power
D.F.: Focal depth
View field 1: Field of view when using $\phi 24\text{mm}$ eyepiece
View field 2: Field of view when using $1/2''$ CCD camera

MSM-400

SERIES 377 — Stereo Microscopes

FEATURES

- Bright, sharp images with real depth are produced with high resolution and excellent faithfulness to color, thus minimizing eye fatigue while increasing inspection efficiency and productivity.
- The MSM series provides a full range of advanced functions at an affordable price.
- User-friendly turret types (MSM-412, MSM-465) and a zoom type (MSM-Z414) are available.
- Continuous zooming, a standard feature, allows you to enlarge the object by 10 to 40 times in total magnification.
- MSM series can be connected to a digital camera or CCD camera to save captured images of the object or for simultaneous observation through different media.
- The extended depth of focus, long working distance and wide field of view increase work efficiency. The system is ideal for inspecting various objects such as electronic components, metal components, plants, mineral compositions and biological cells.
- Various attachments expand applications and use. Extended MSM units can be used for appearance inspections, on processing lines, inside inspection systems or in teaching environments.



MSM-412



MSM-Z475T



MSM-Z414



MSM-465

SPECIFICATIONS

Model No.	MSM-412	MSM-Z414	MSM-Z475	MSM-Z475T	MSM-465
Order No.	377-925	377-945*	377-975*	377-985*	377-965*
Optical system	Greenough's type				Galilean type
Total magnification	10X, 20X	10X to 40X	7.5X to 50X		6X, 12X, 25X, 50X
Optical tub	Binocular	Binocular	Binocular	Trinocular	Binocular
Pupil distance (adjustable)	54 - 76mm	54 - 76mm	52 - 79mm		54 - 76mm
Eyepiece (optional)	WF5X/22, WF10X/20 (standard), WF15X/13, WF20X/10	WF5X/22, WF10X/20 (standard), WF15X/13, WF20X/10	WF10X/23 (standard), WF5X/23, WF6.25X/23, WF15X/17, WF20X/13, WF32X/8		WF6.25X/23, WF10X/23 (standard), WF15X/17.6, F20X/13.4, WF32X/10
Objective	1X, 2X (turret)	1X to 4X (zoom)	0.75X to 5X (zoom)		1.2X, 2.5X, 5X (turret)
Auxiliary objective (optional)	—	0.5X, 0.75X, 1.5X	0.5X, 0.63X, 1.5X, 2X		0.6X, 1.2X, 2.5X, 5X
Total magnification	2.5X to 60X	2.5X to 120X	1.87X to 320X		3.75X to 320X
Working distance of objective	95mm	80mm	113mm		89mm
Focusing travel	44mm	44mm	50mm		50mm
Maximum workpiece height	93mm	95mm	130mm		95mm*
Workstage size	ø95mm	ø95mm	ø95mm		ø95mm
Dimensions	151x285x343mm	151x285x343mm	151x285x343mm		151x285x343mm
Mass	4.9kg (377-925B) 4.7kg	5.3kg (377-945B) 5.1kg	5.3kg	5.4kg	4.8kg (377-965B) 6.3kg

* To denote your AC power cable add the following suffixes to the order No.: **A** for UL/CSA, **C** for Taiwan, **D** for CEE, **DC** for CCC, **E** for BS, **K** for EK, **No suffix** is required for JIS/100V

Optional Lenses For MSM-412, Z414



5X/22 eyepiece:
377-026



15X/13 eyepiece:
377-028



20X/10 eyepiece:
377-029



0.5X Auxiliary
objective
377-045



0.75X Auxiliary
objective
377-046



1.5X Auxiliary
objective
377-047

For MSM-465



6.25X/23 eyepiece:
377-066



15X/17.6 eyepiece:
377-067



20X/13.4 eyepiece:
377-068



32X/10 eyepiece:
377-069



0.5X Auxiliary
objective
377-076

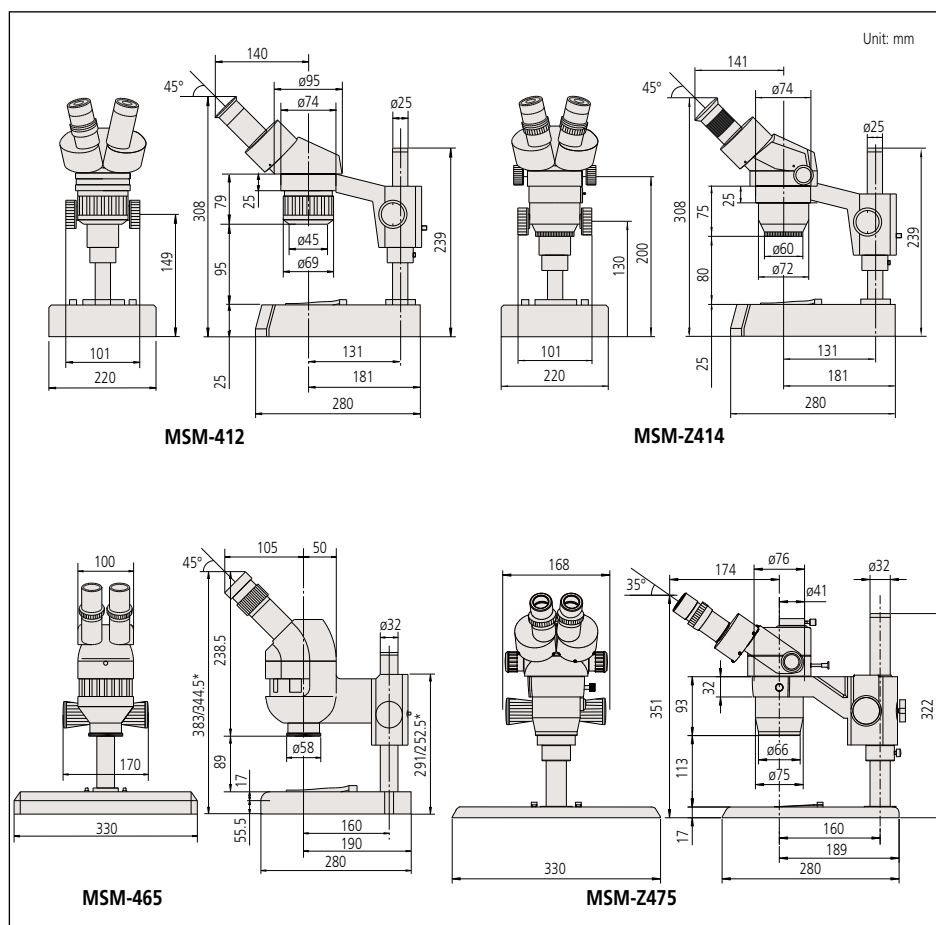


1.5X Auxiliary
objective
377-077



2X Auxiliary
objective
377-078

DIMENSIONS



MSM-465



MSM-Z414



Pocket Magnifiers

SERIES 183

FEATURES

- Suitable for inspecting metal surfaces.

SPECIFICATIONS

Magnification	Order No.	Remarks
25X	183-201	Pen type
	183-202	With stand
50X	183-203	With stand



183-201



183-202



183-203

Pocket Comparators

SERIES 183

FEATURES

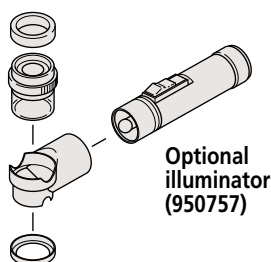
- By replacing optional reticles, dimensional, angle, and other types of measurement can be performed.
- An optional illuminator (950757) is available.

SPECIFICATIONS

Magnification	Order No.	Remarks
8X	183-101	Optional reticles available
9X	183-121	Optional reticles available
10X	183-131	Optional reticles available

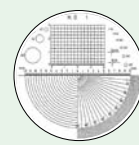


183-101



Optional illuminator (950757)

Optional Reticles for pocket comparators



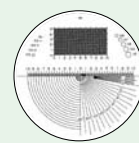
183-102



183-103



183-104



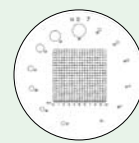
183-105



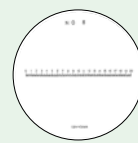
183-106



183-107



183-108



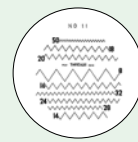
183-109



183-110



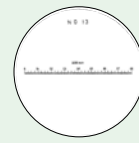
183-111



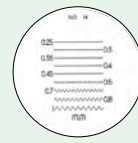
183-112



183-113



183-114



183-115

Zoom loupe

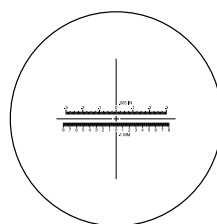
SERIES 183

FEATURES

- Allows the user 8X - 16X zoom observation.
- Magnification indicator is provided for 8X, 10X, 12X, 14X, and 16X observation.
- Metric and inch scales are provided for measuring.
- Comes with a carrying case.



183-304



Reticle provided

SPECIFICATIONS

Magnification	Order No.	Remarks
8X	183-304	With reticles (Scale graduation: 0.1mm, .005")

Clear Loupe

SERIES 183



183-301



183-302



183-303

SPECIFICATIONS

Magnification	Order No.	Remarks
7X	183-301	Drawtube removable
10X	183-302	Drawtube removable
15X	183-303	Drawtube removable